

International School of
Subnuclear Physics (ISSP)
58th Course

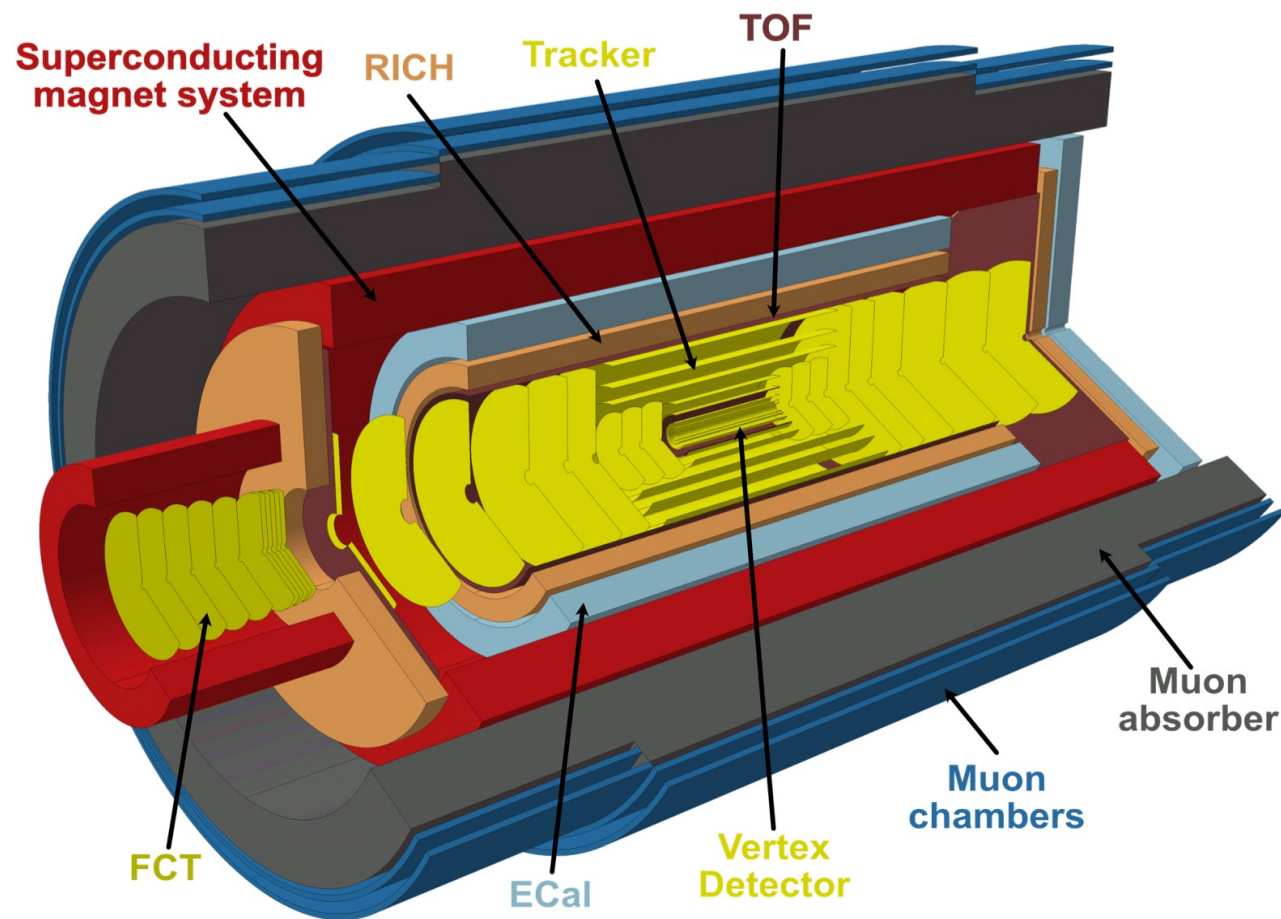
15-24/06/2022

Performance study of LGADs for the ALICE 3 timing layers

Sofia Strazzi

University of Bologna, Italy





ALICE 3: a next generation heavy-ion experiment



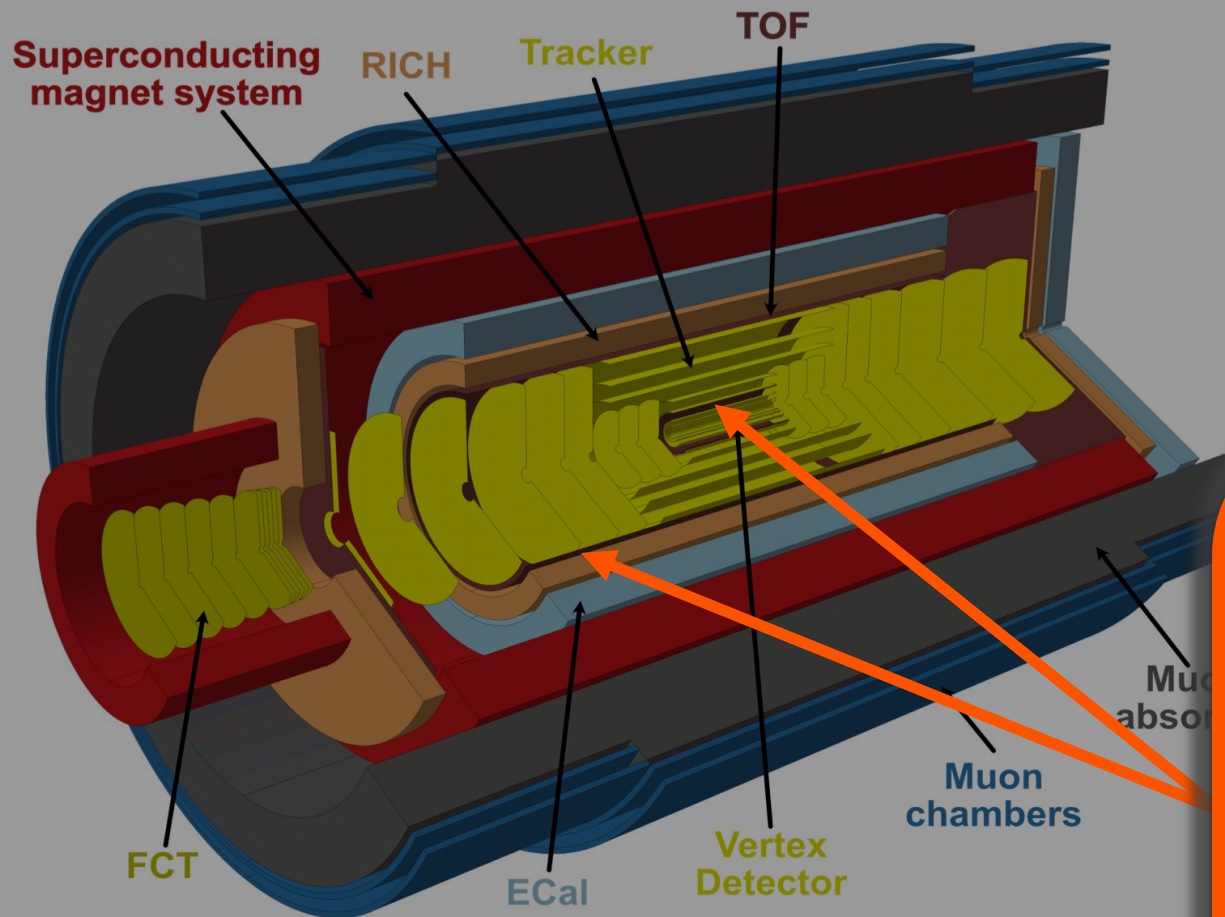
Nearly mass-less, based on the most advanced silicon technologies

- Excellent **PID**
- Secondary **vertex finding**
- Reconstruction efficiency at very **low momenta**



New exciting opportunities for the study of:

- ✦ **Heavy flavor** hadrons
- ✦ electromagnetic and hadronic **probes of the QGP** at very low momenta



ALICE 3: a next generation heavy-ion experiment

Nearly mass-less, based on the most advanced silicon technologies

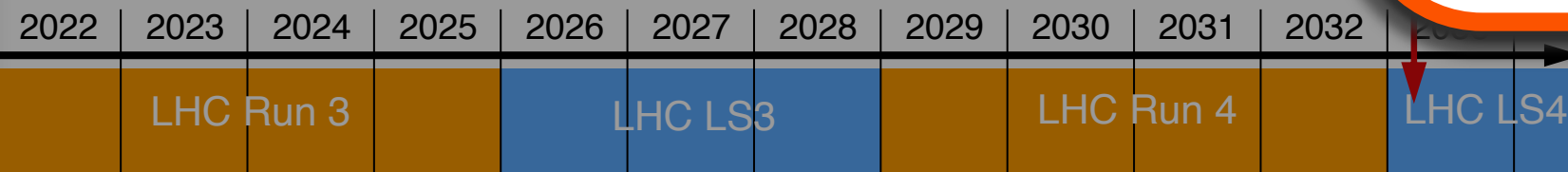
- Excellent **PID**
- Secondary **vertex finding**
- Reconstruction efficiency

Silicon-based Time-Of-Flight (TOF)

Required time resolution

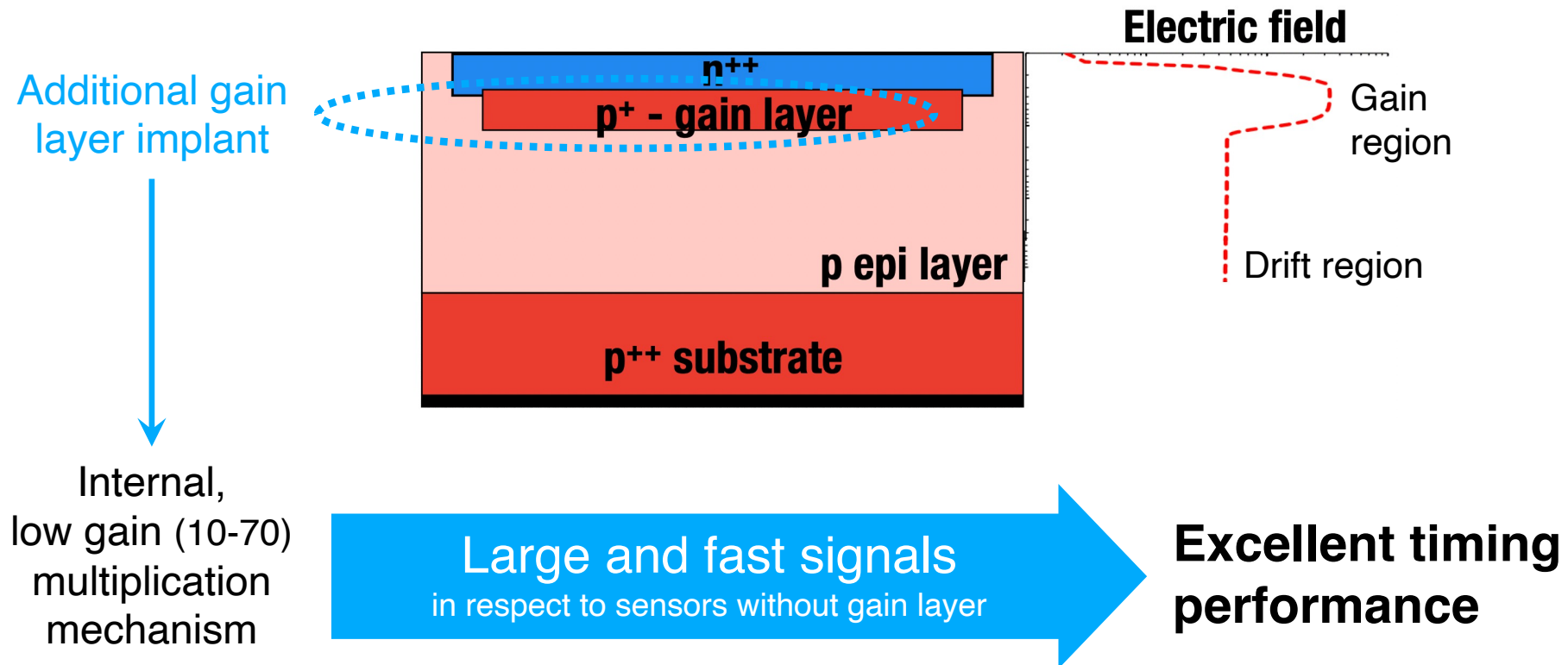
20ps

Several **innovative technologies** are under evaluation

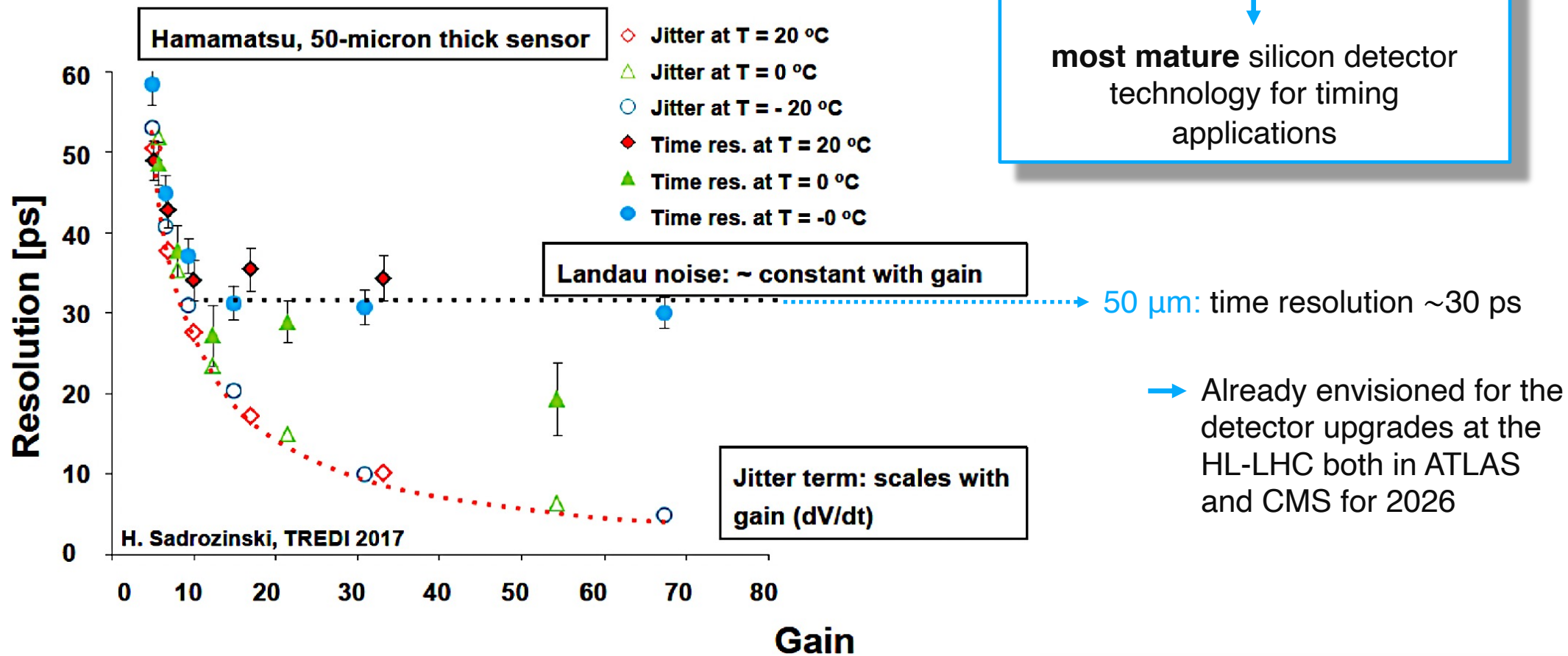


LOW GAIN AVALANCHE DETECTOR (LGAD)

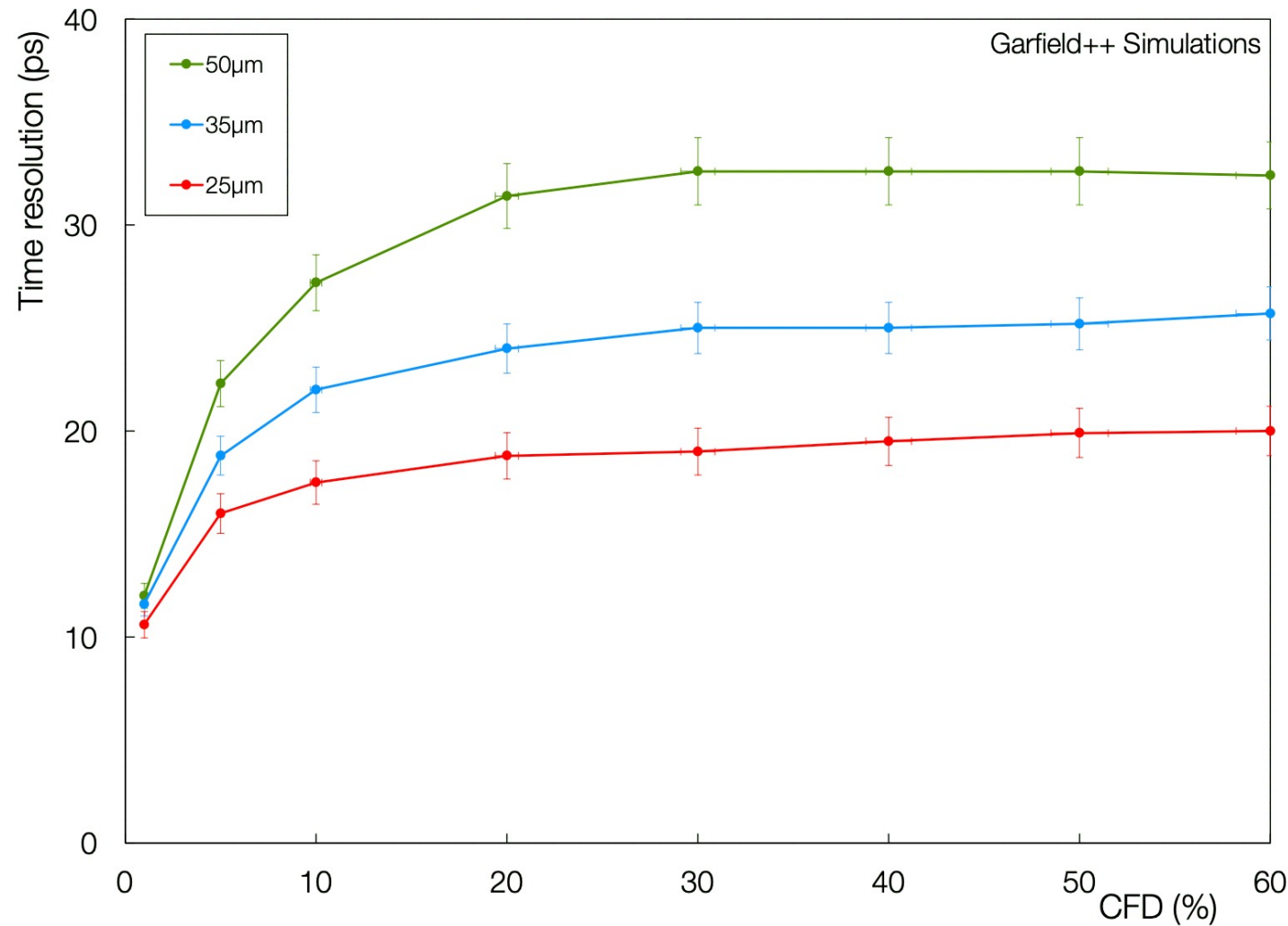
Developed to detect charged particles → Evolution of n-in-p standard sensors



STATE OF THE ART



MOTIVATIONS



Already envisioned for the detector upgrades at the HL-LHC both in ATLAS and CMS for 2026

ALICE 3 Timing Layers need an even better time resolution **~20 ps**

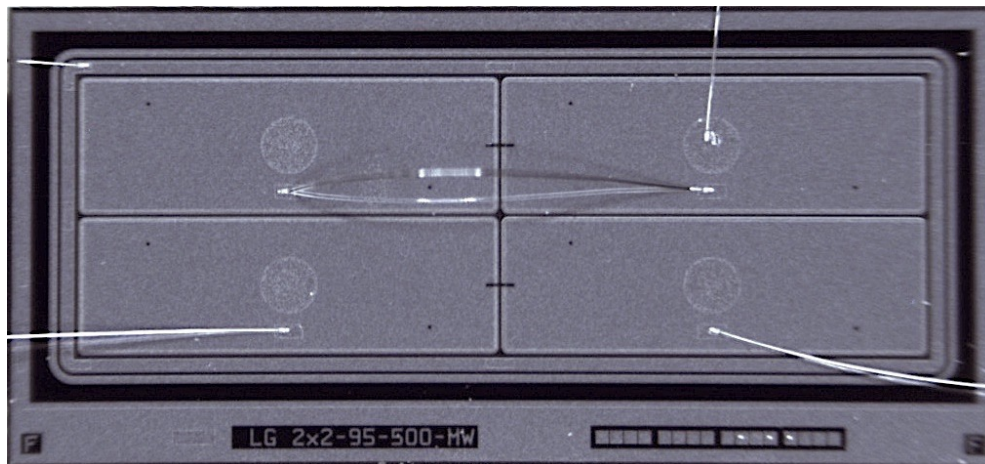
A **thinner** LGAD design could match the requirements

TESTED LGADs

50 μm -thick HPK LGAD

With known resolution

- Comparison
- Results confirmation

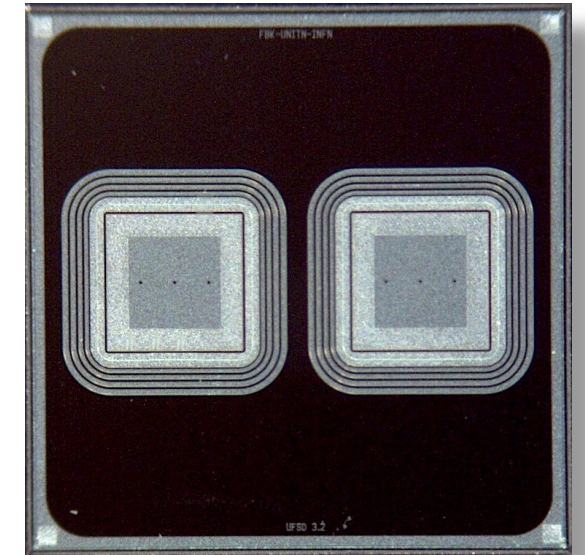


1x3 mm²

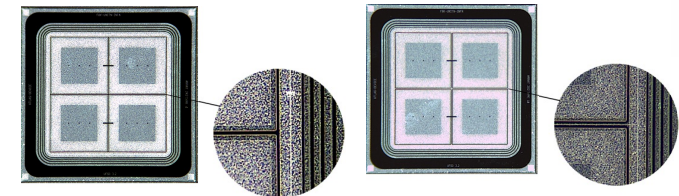
First very thin LGAD prototypes produced by FBK

25 μm and
35 μm -thick FBK
single channel

1x1 mm²



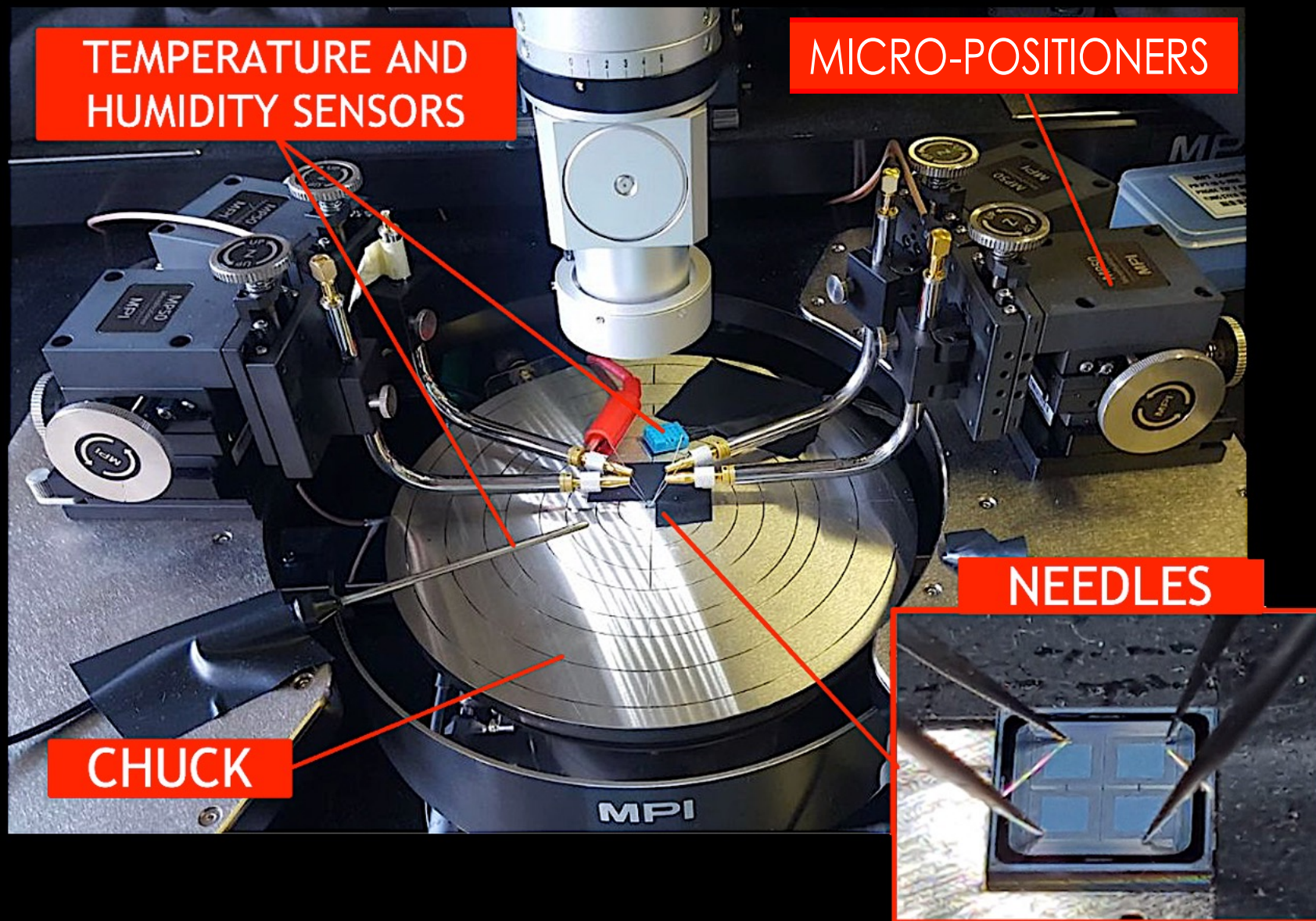
Matrices 1.3x1.3 mm²



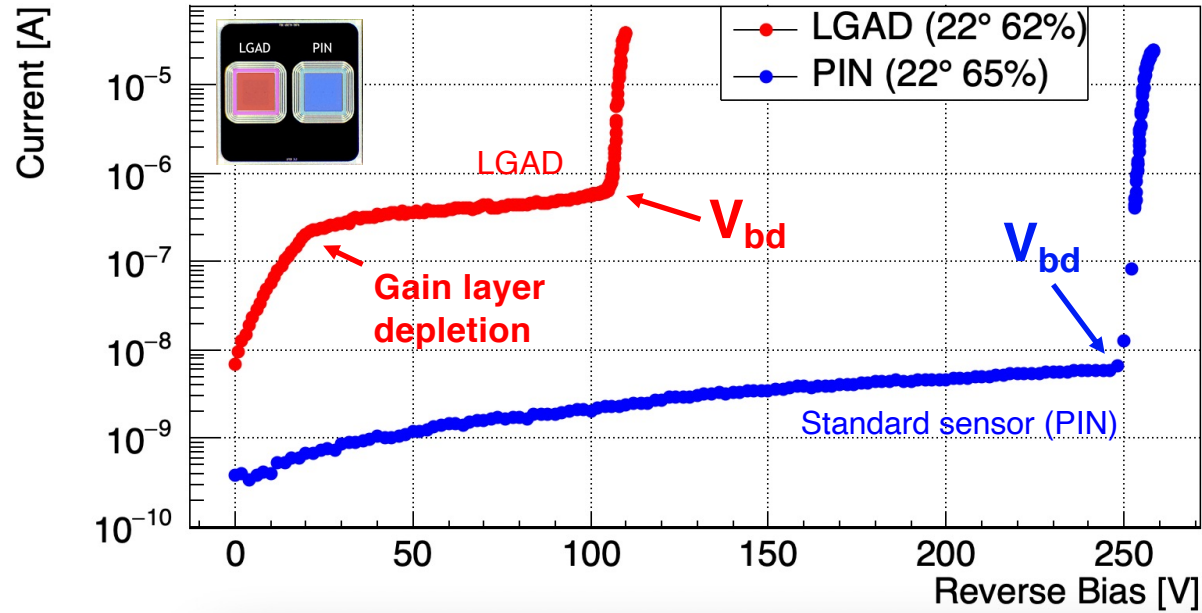
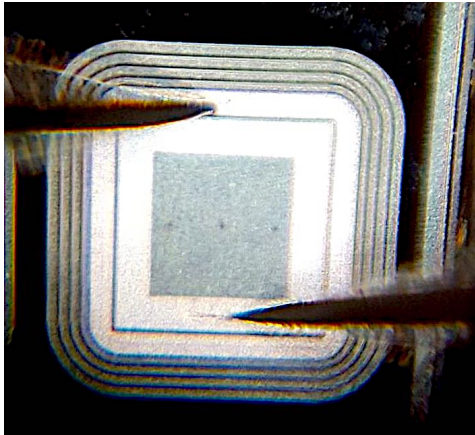
IV

CV

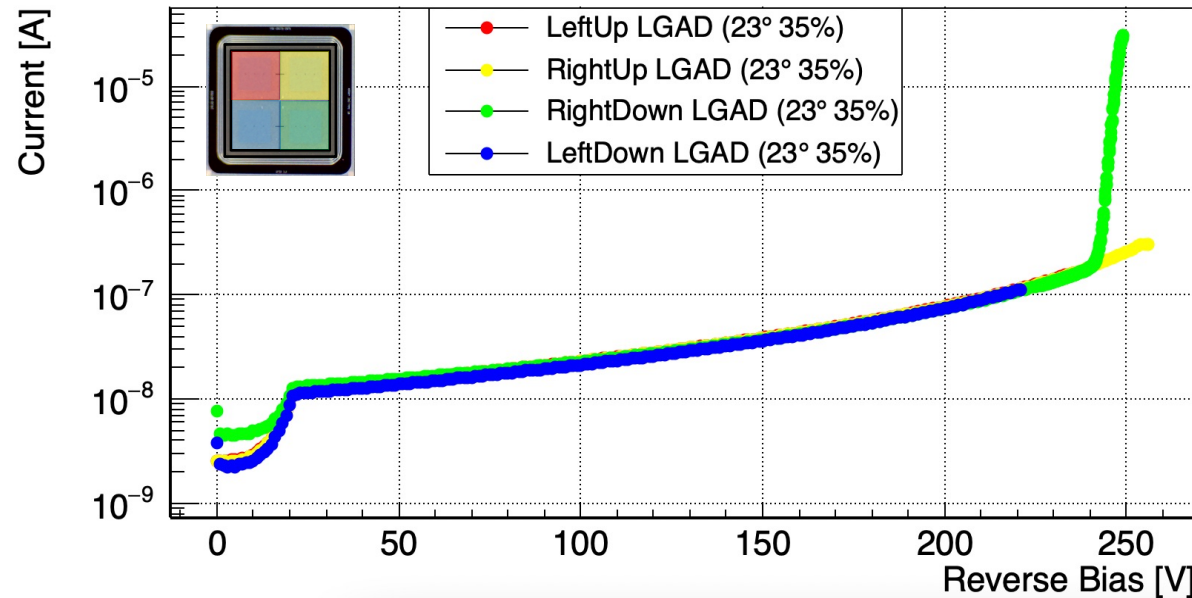
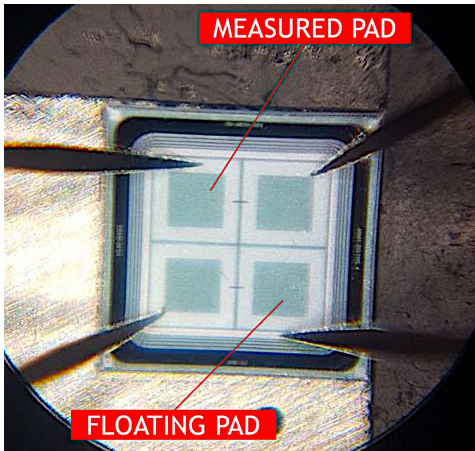
ELECTRICAL CHARACTERIZATION



PIN-LGAD



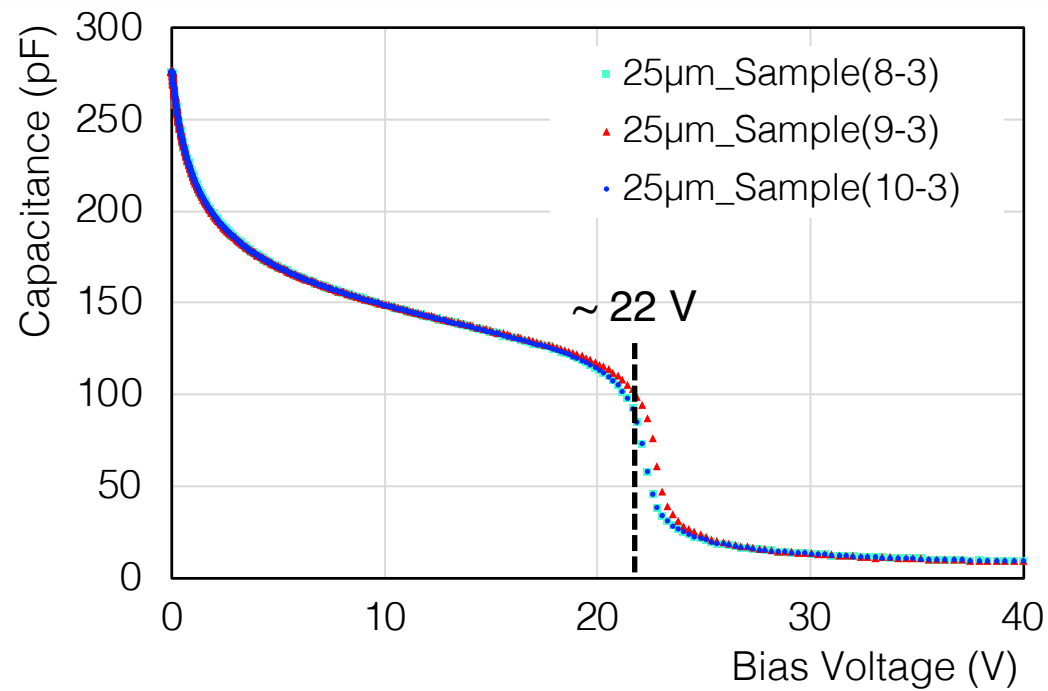
MATRIX



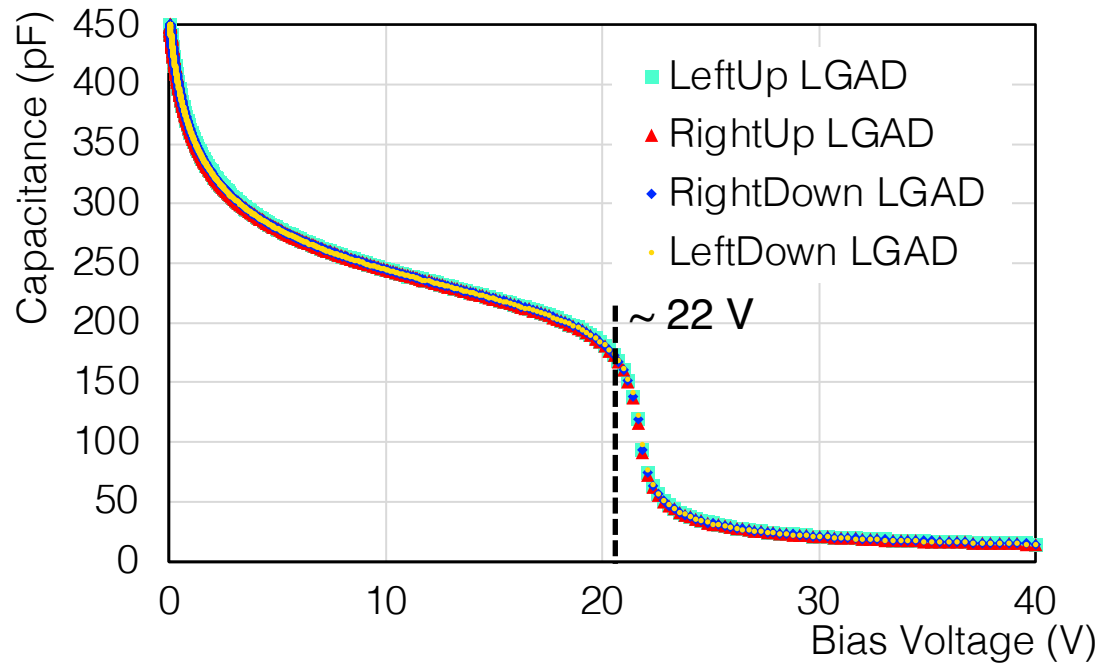
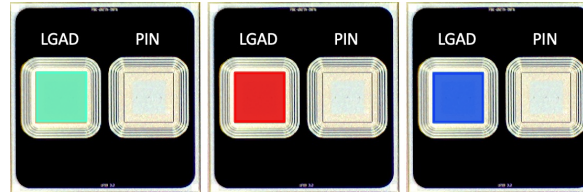
IV

CV

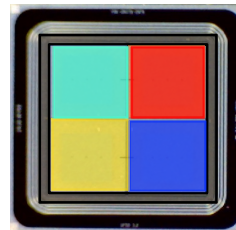
- Breakdown V
- Voltage interval of operation
- Evaluate inter-pad configuration



Sensors with the
same wafer (25 μm)



Pads of a same
matrix



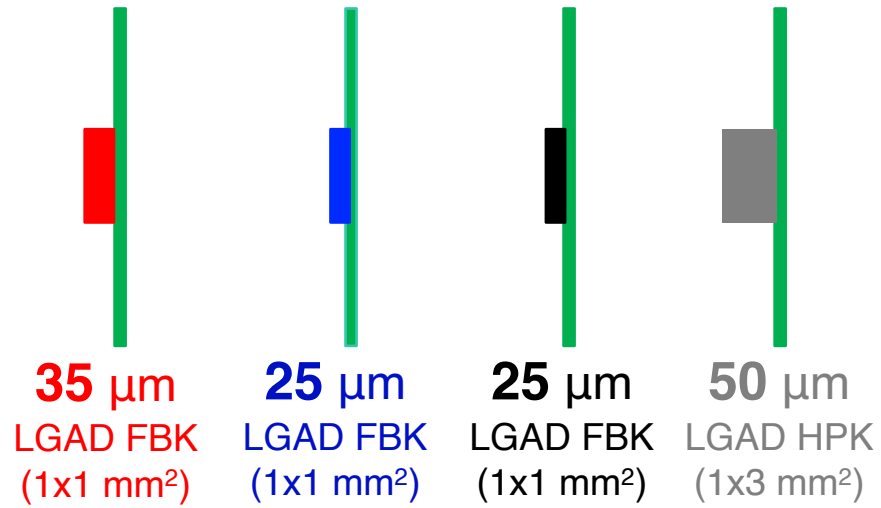
Totally negligible
non-uniformities

IV

CV

- Gain layer depletion V
- Full depletion V
- Connected to the doping profile

BEAM
 π 12 GeV/c



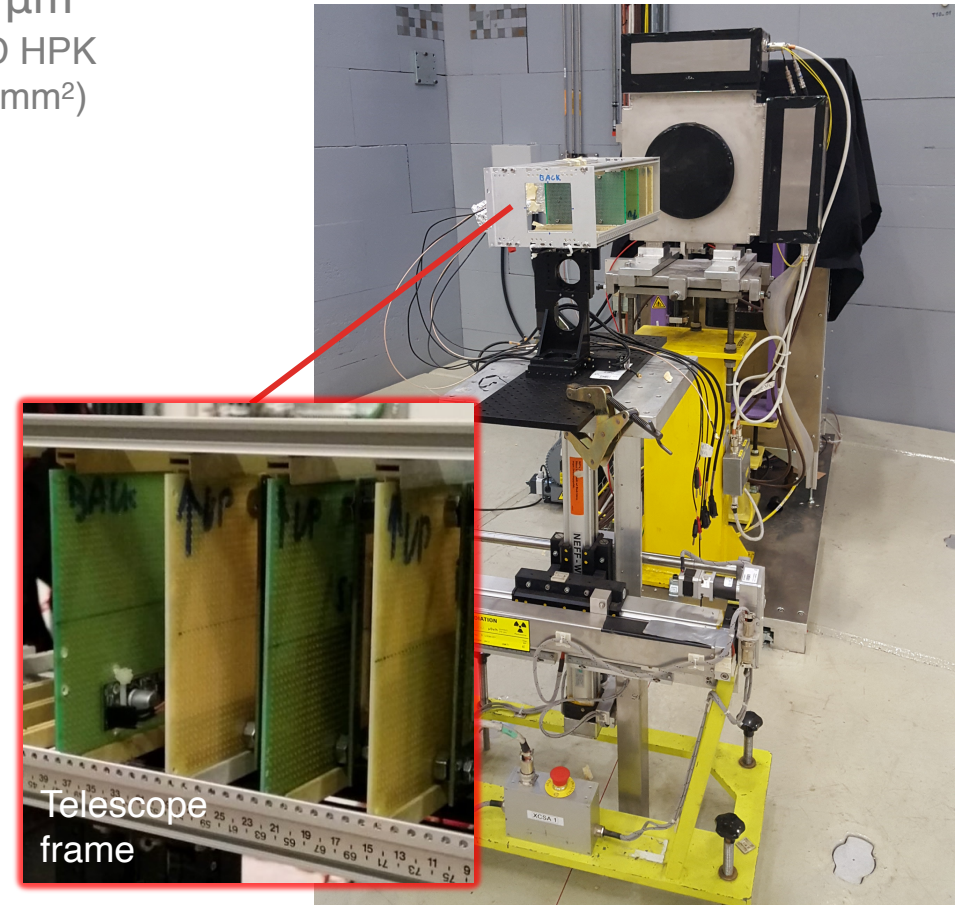
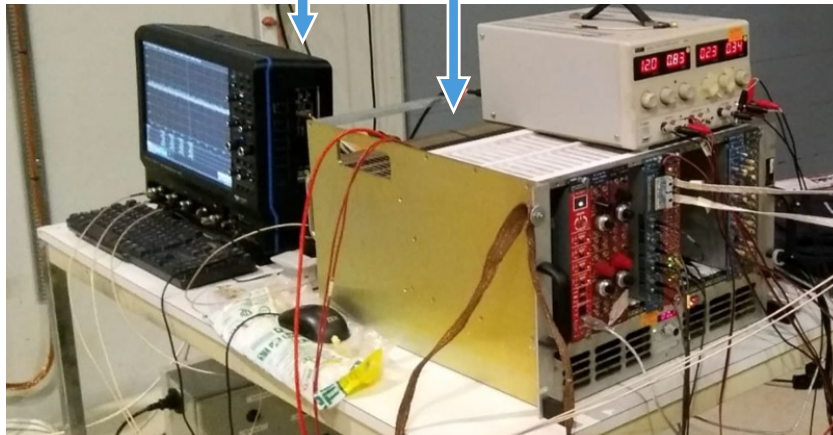
TEST BEAM SETUP

LeCroy WaveRunner 9404M-MS

Sampling rate: 20 GS/s

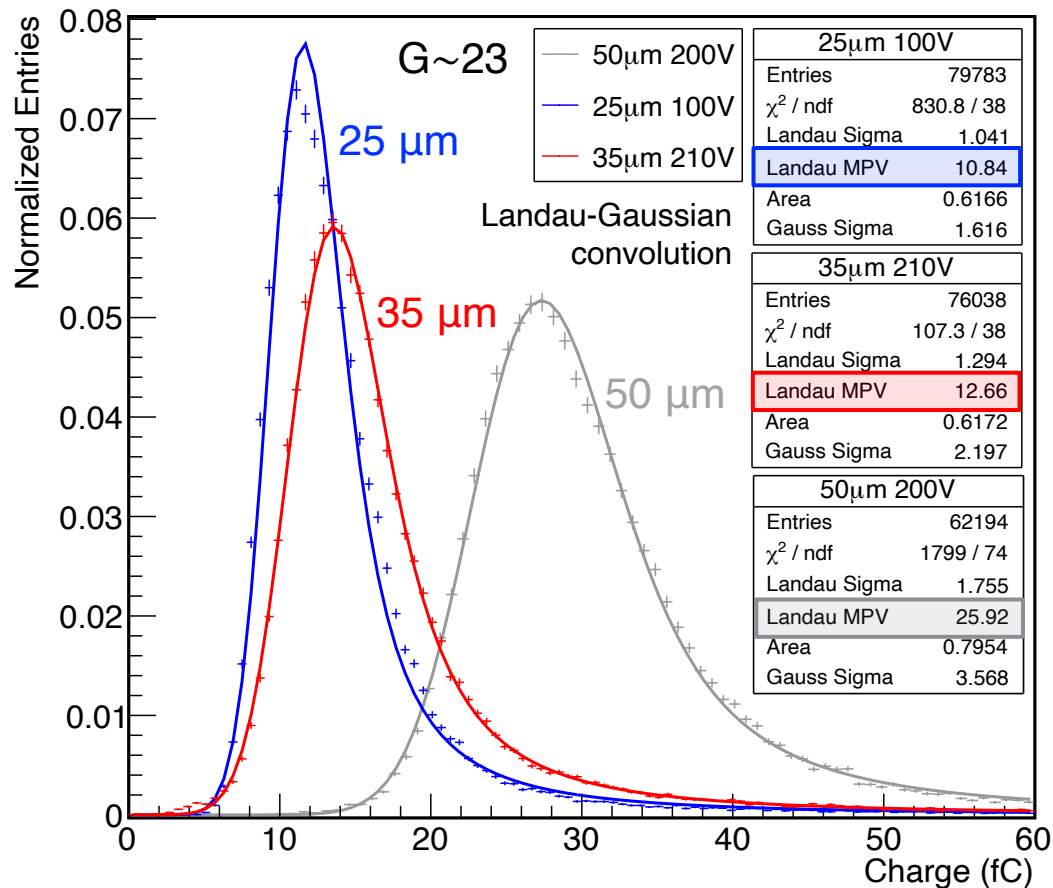
Time discretization: 50 ps

CAEN power supply

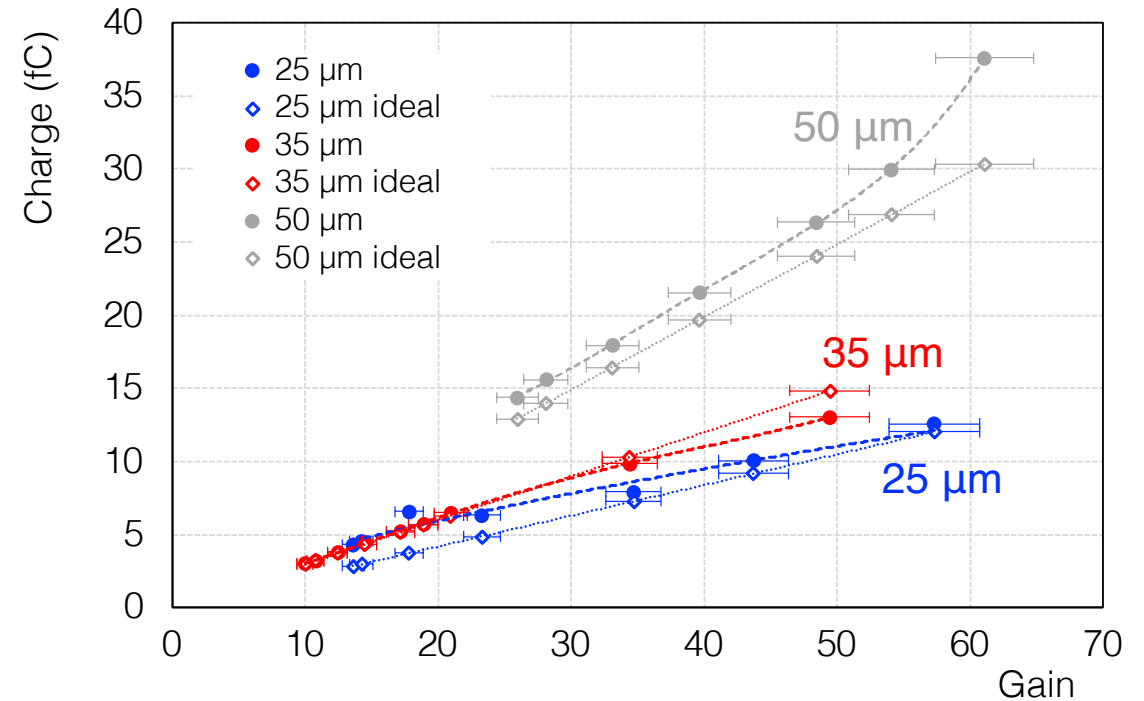


CHARGE DISTRIBUTIONS

Charge MPV increases with the thickness →



Measured Charge MPV vs Ideal

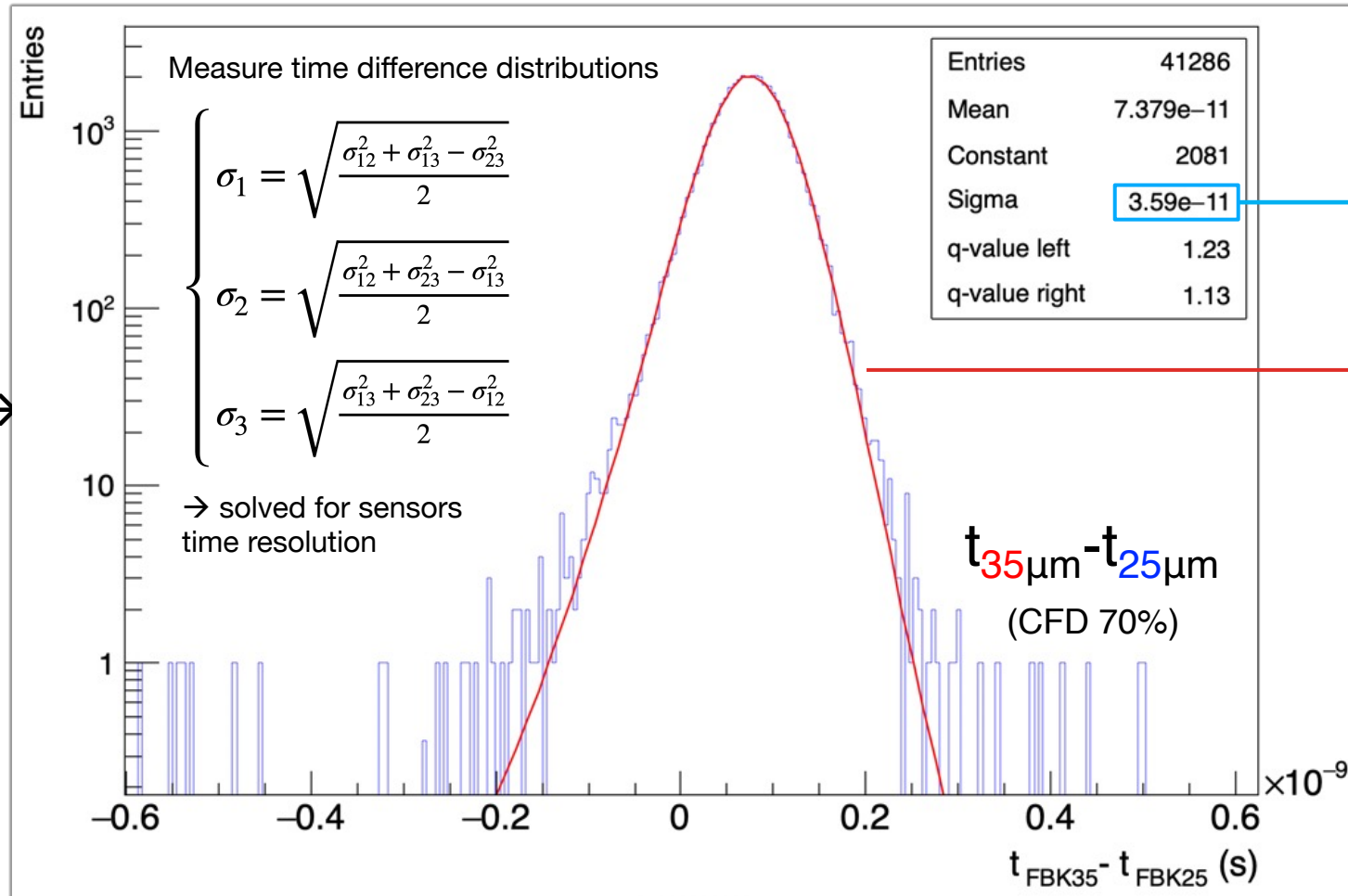


$$\text{Ideal Charge} = \text{Charge}_{\text{PIN}} \times \text{Gain}_{\text{meas}}$$

→ results are in good agreement with the expected values

DATA ANALYSIS FOR THE TIMING PERFORMANCE

Constant fraction discrimination (CFD) technique



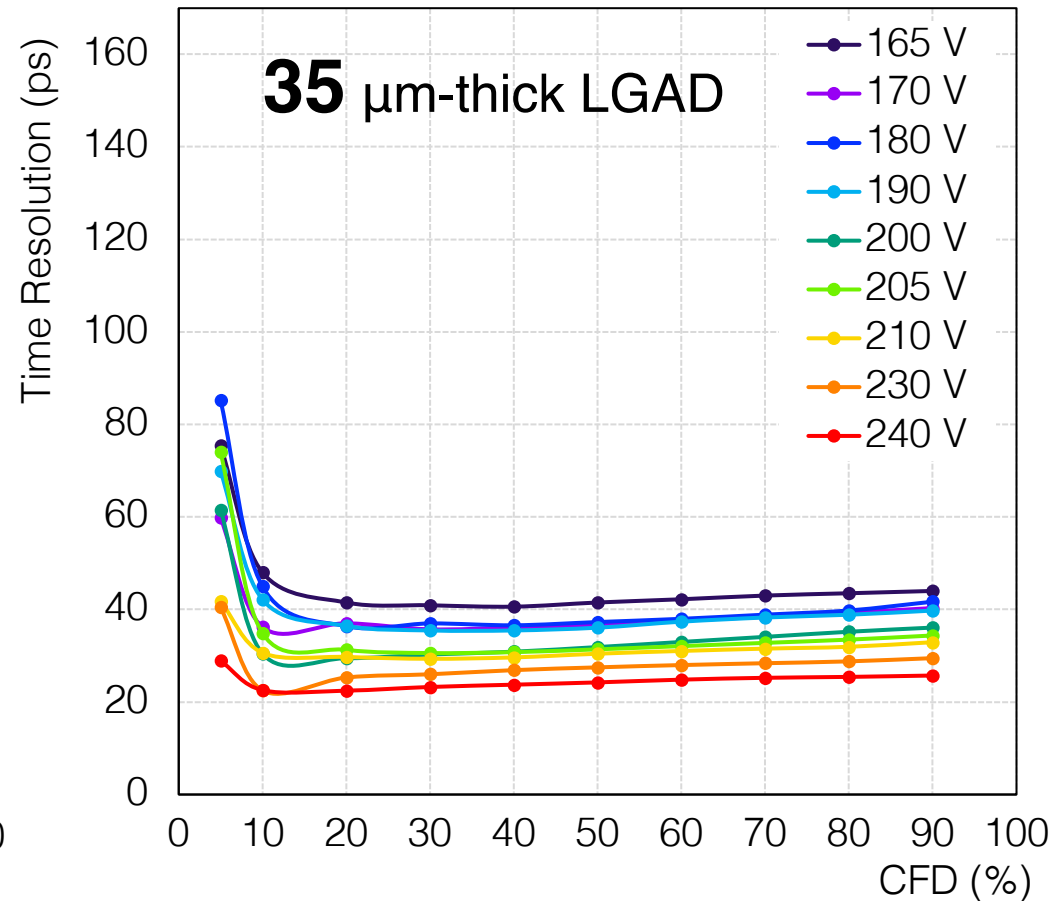
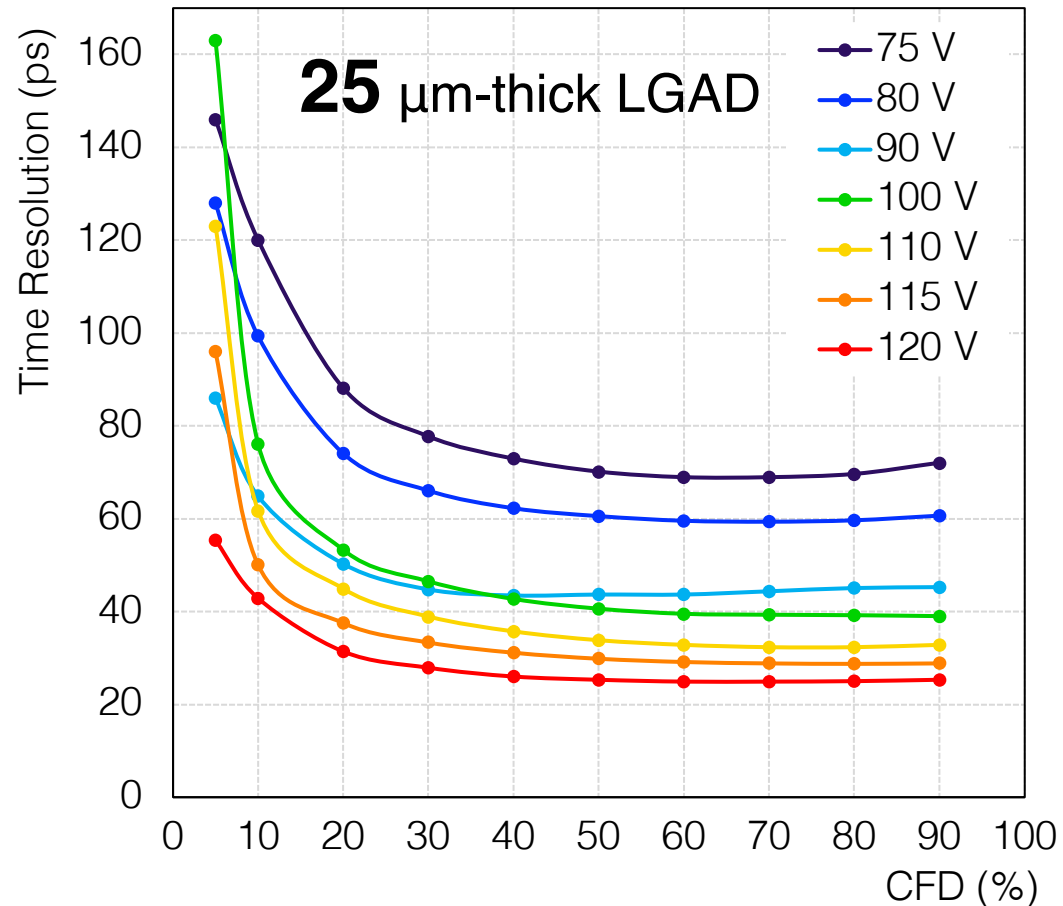
Measurements in full bandwidth (4 GHz) $\xrightarrow{\text{Smoothing to remove high frequency noise}}$ 1 GHz

Difference between the threshold crossing time of each couple

Asymmetric q-Gaussian fit

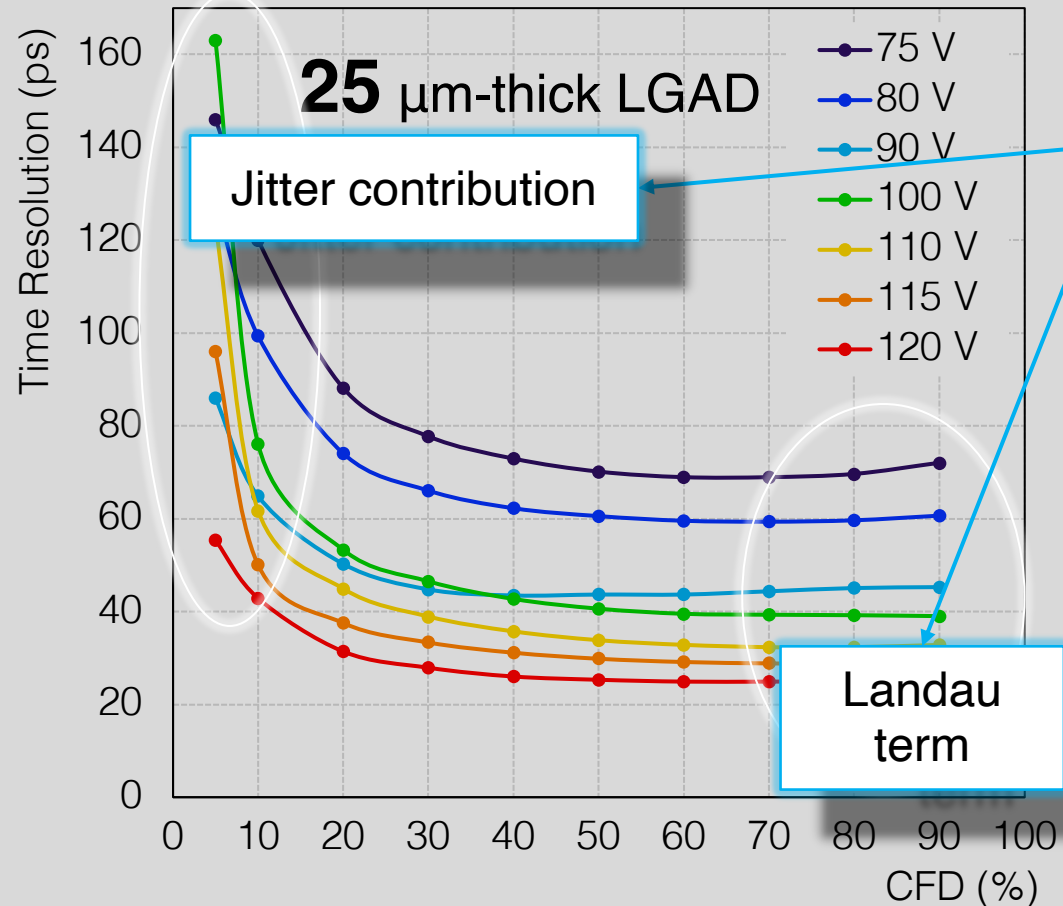
- Gaussian shape of the arrival times
- small tails (2.5% of the measures)

TIMING PERFORMANCE



Trend and values of **50 μm LGAD** totally in agreement with previous results

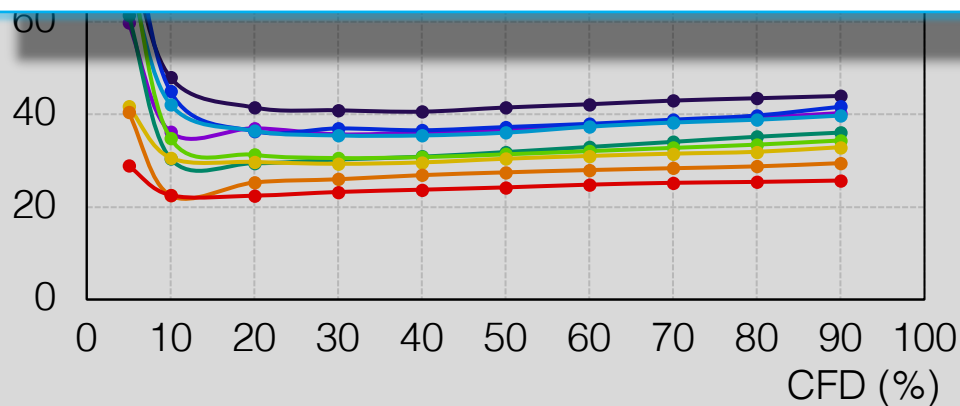
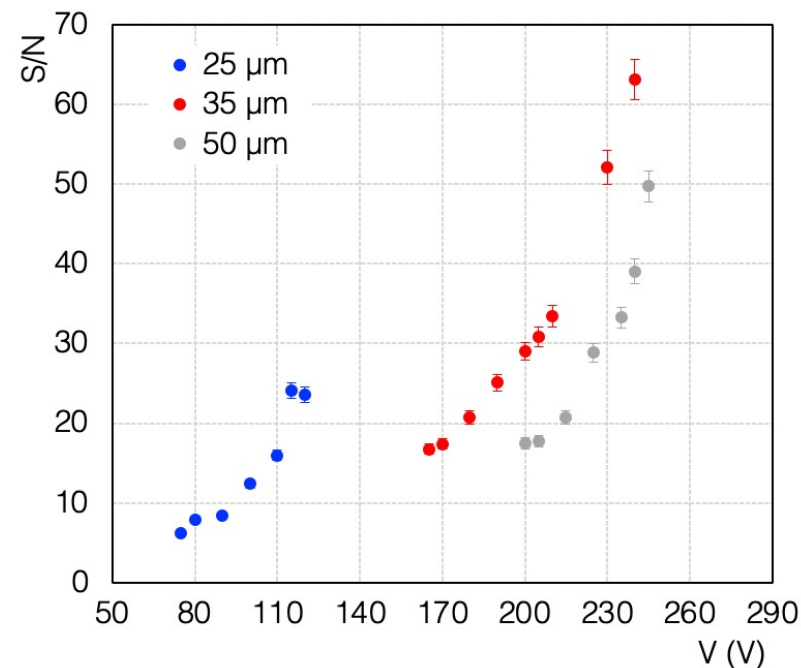
TIMING PERFORMANCE



- Thickness
- S/N

- Electronics
- Detectors
- Shielding

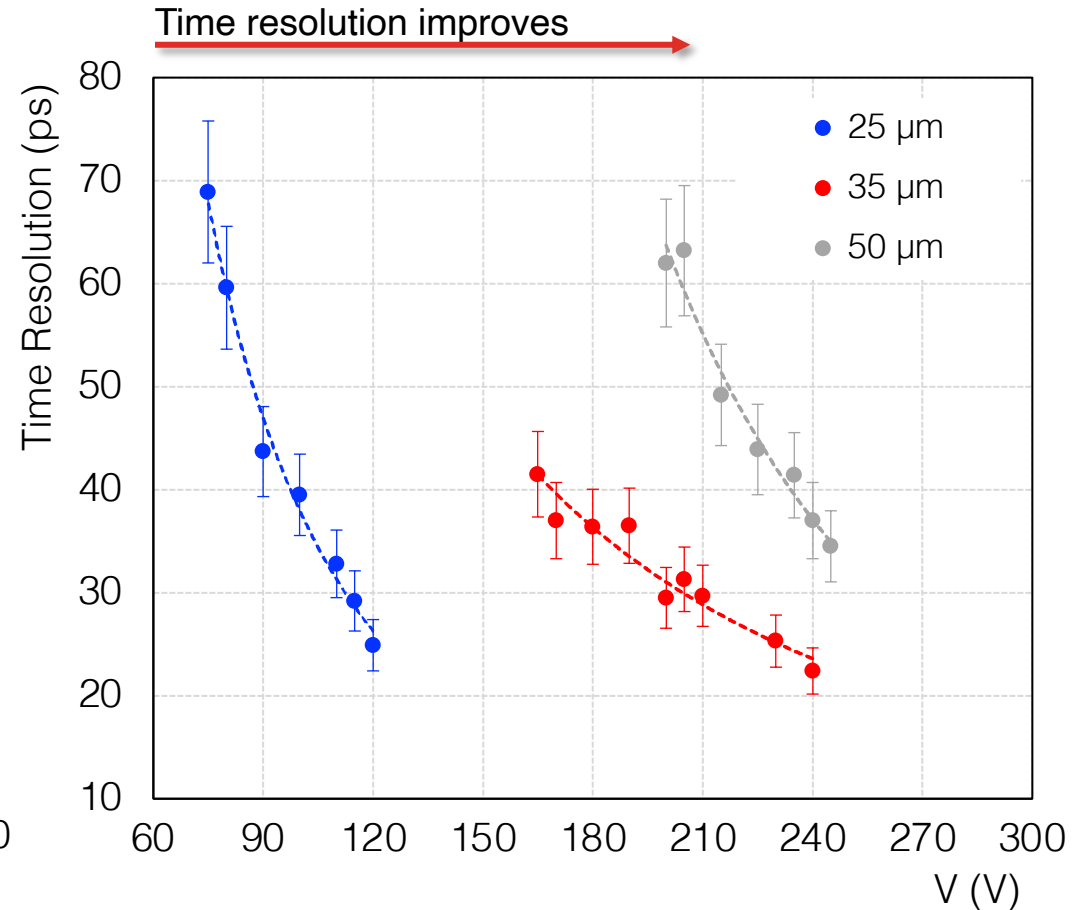
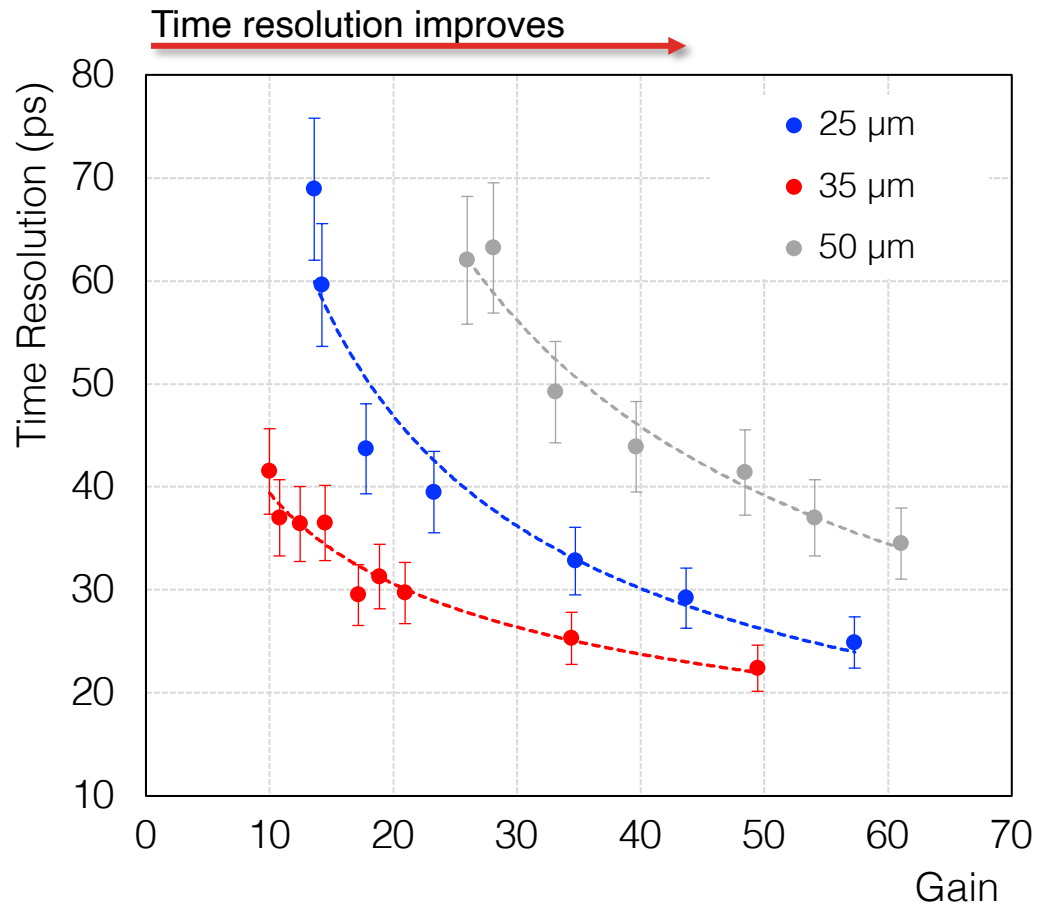
25 μm : 6-24
35 μm : 16-63



Trend and values of 50 μm LGAD totally in agreement with previous results

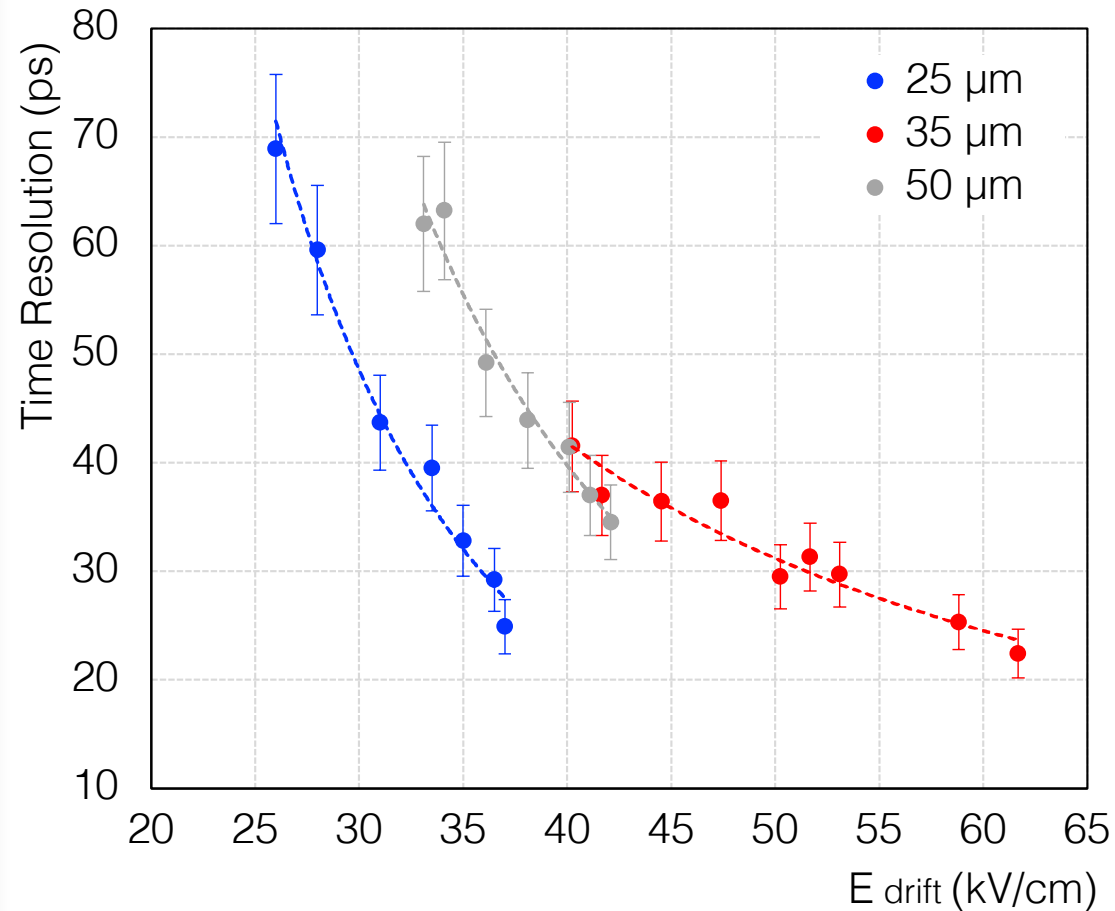
TIMING PERFORMANCE

- 50 μm LGAD $\rightarrow$ ~ 34 ps confirms previous results
- Better values for thinner detectors ($\searrow$ Landau term)
- 25 & 35 μm are compatible within the uncertainties ~ 25 ps & 22 ps
 $\rightarrow$ worse S/N, not optimized wafer production

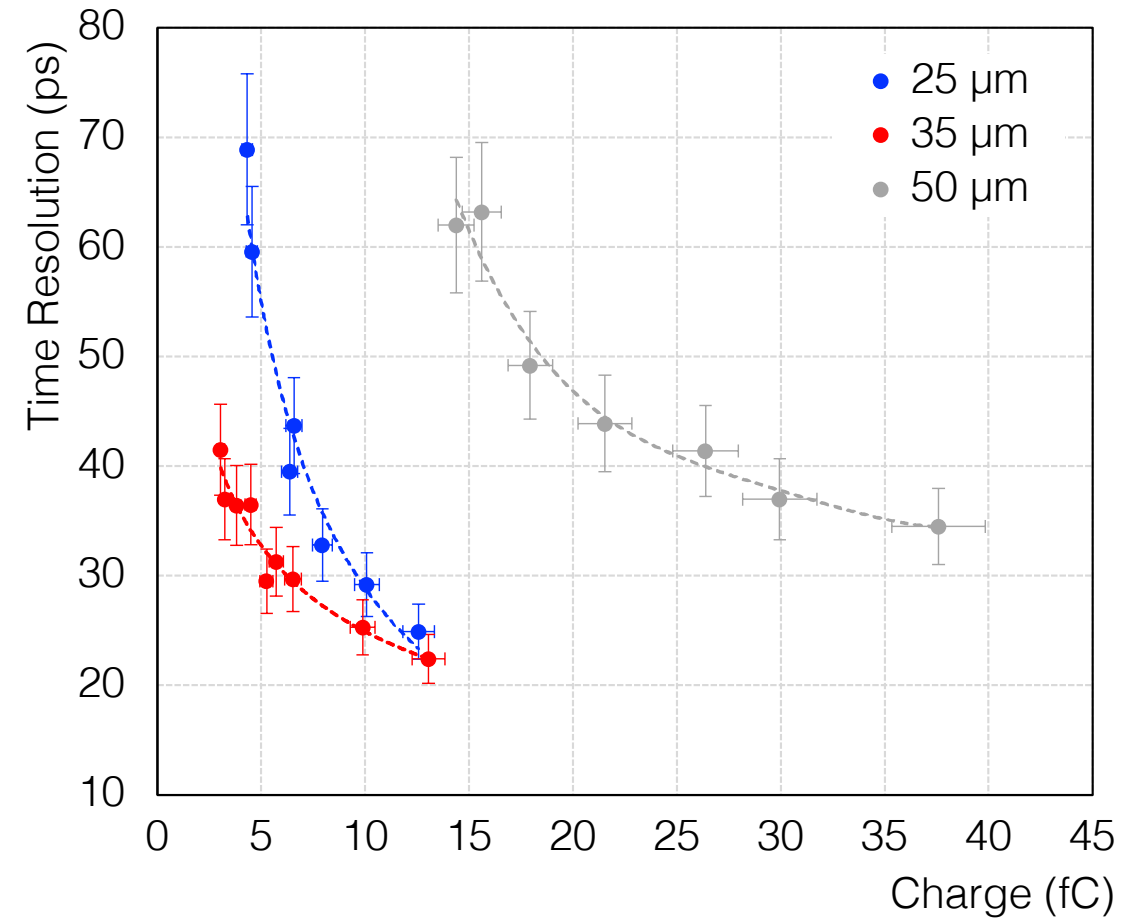


TIMING PERFORMANCE

DRIFT ELECTRIC FIELD



CHARGE



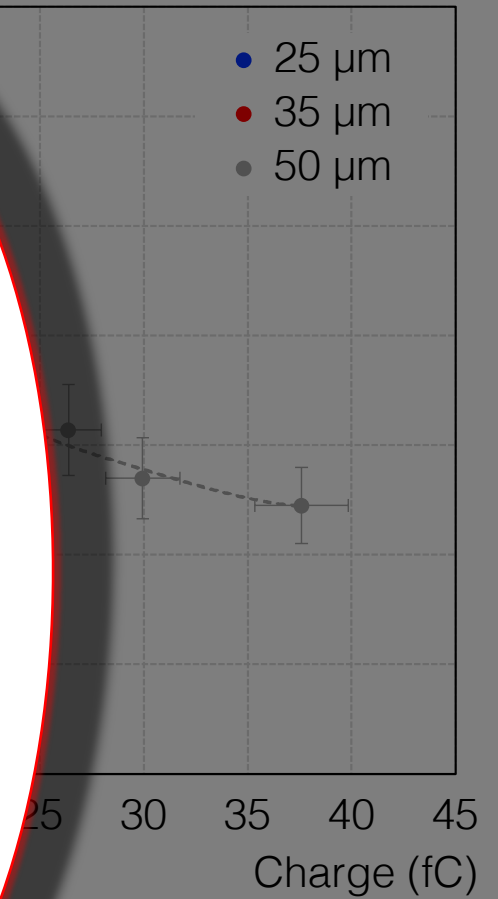
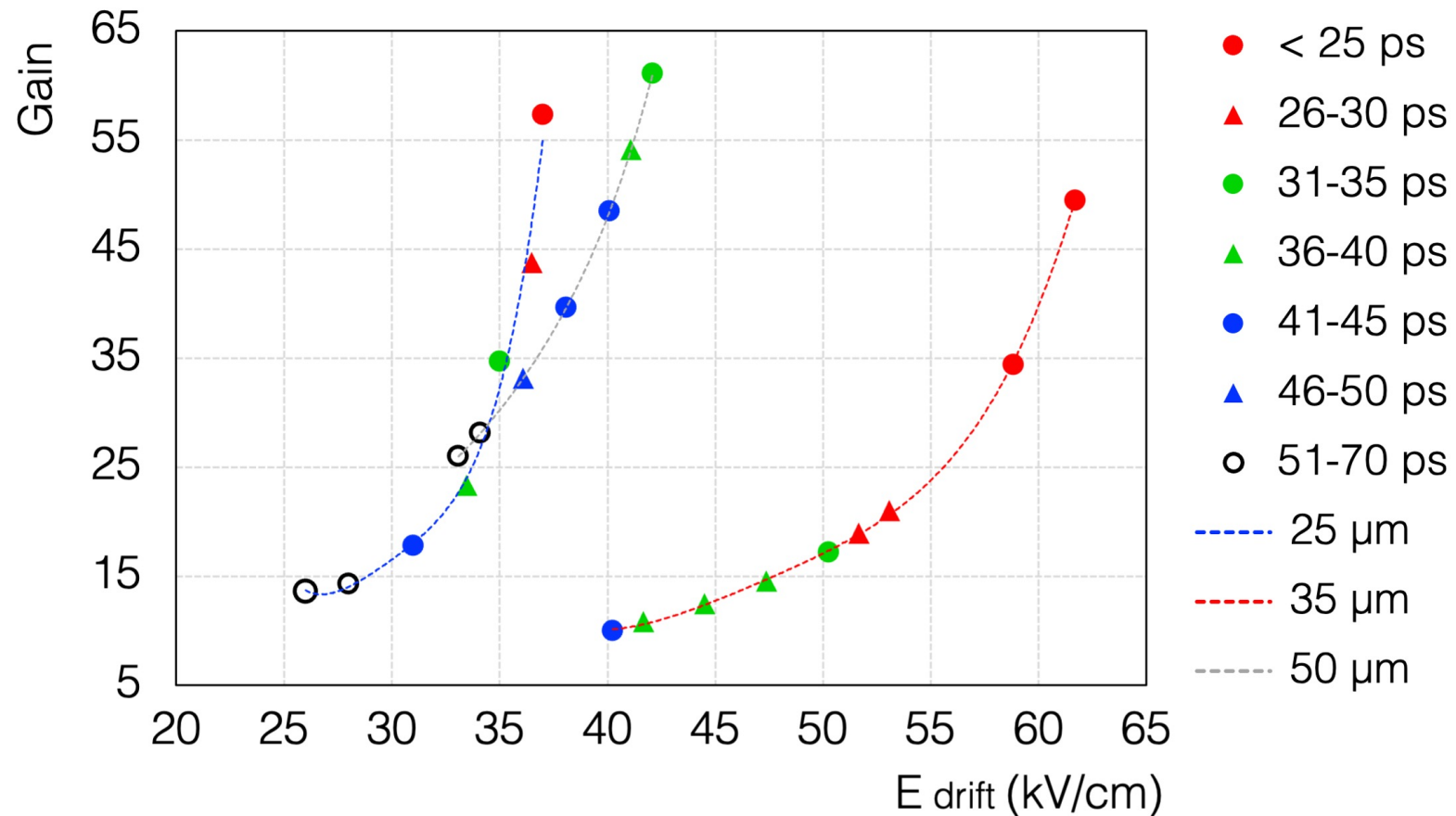
* E_{drift} → Electric field inside the silicon bulk (drift region)

→ extracted from the data considering V and Thickness (*Weightfield simulation for the 25 μm*)

TIMING PERFORMANCE

CHARGE

To obtain a good time resolution, a combination of both high **gain** and **drift electric field** is necessary



50 μm (reference) sensor in line with expectations $\rightarrow$ 34 ps

- Experimental setup and analysis procedure have been validated

Thinner detectors:

25 μm $\rightarrow$ 25 ps at 120V

- Slightly worse than simulations (maybe due to fabrication design)

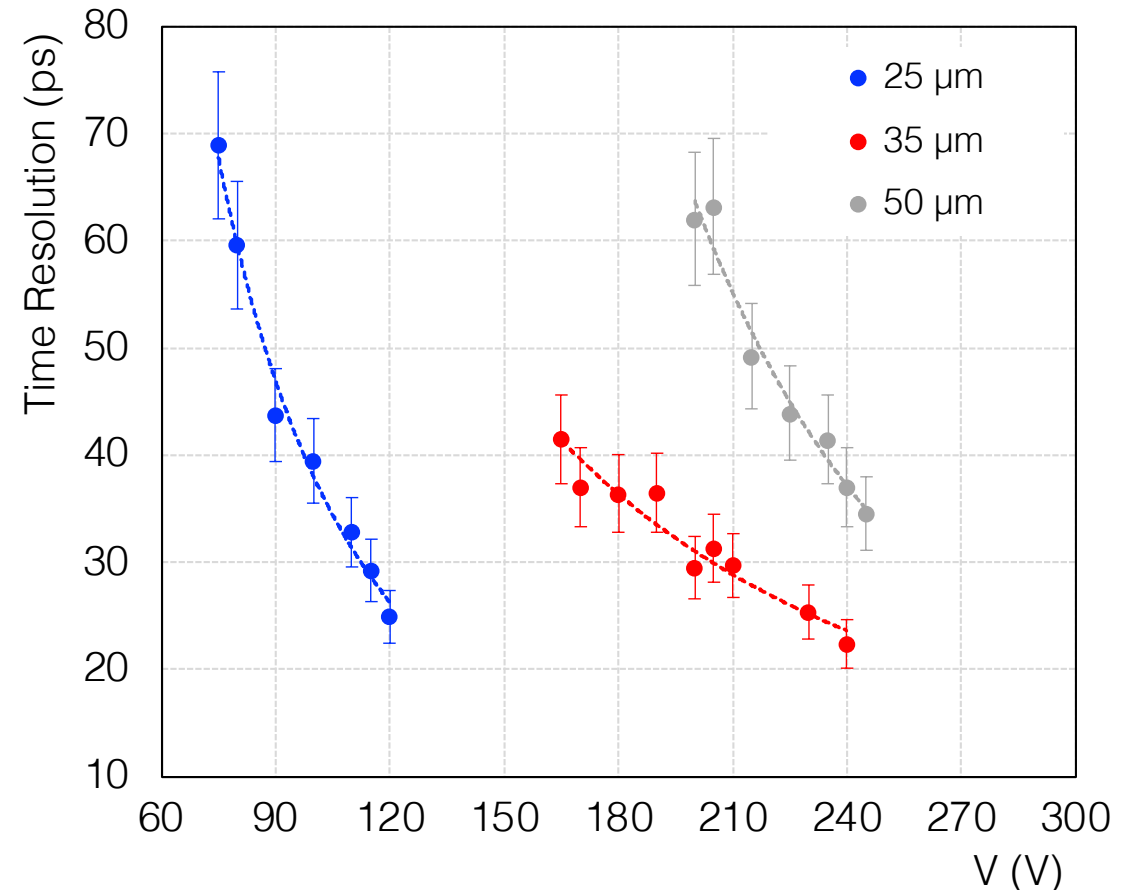
35 μm $\rightarrow$ 22 ps at 240V

- in agreement with MC simulations

Both $\rightarrow$ Improved time resolution with thinner LGAD detectors

CONCLUSIONS

First 25 and 35 μm thick FBK LGAD sensors were tested for the first time in a beam test setup





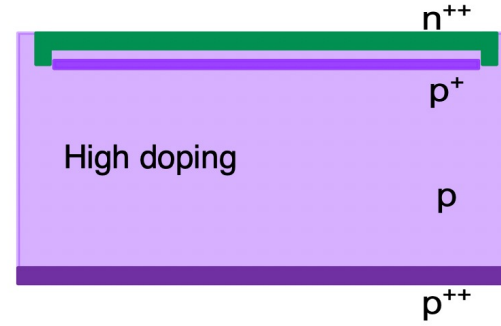
BACKUP SLIDES

Difficulties in the wafer production → Different doping concentrations

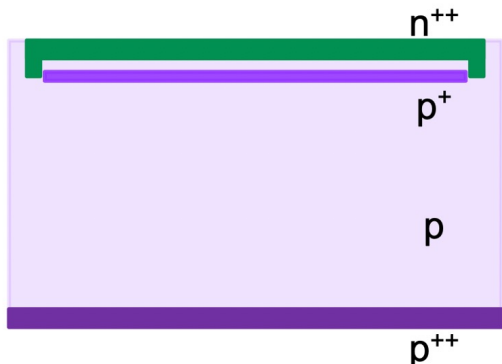
25 μm -thick LGAD



process

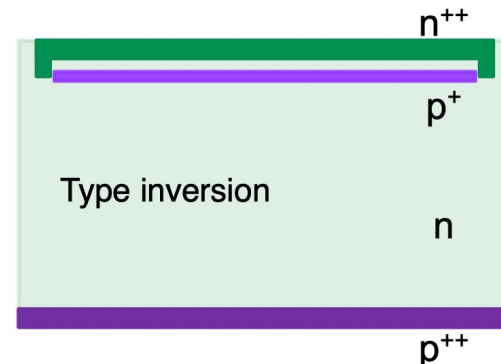


35 μm -thick LGAD



process

oxygen diffusion
(support wafer →
active substrate)



p-type bulk

n-type bulk

ACTIVE THICKNESS

through C-V measurement

25 μm

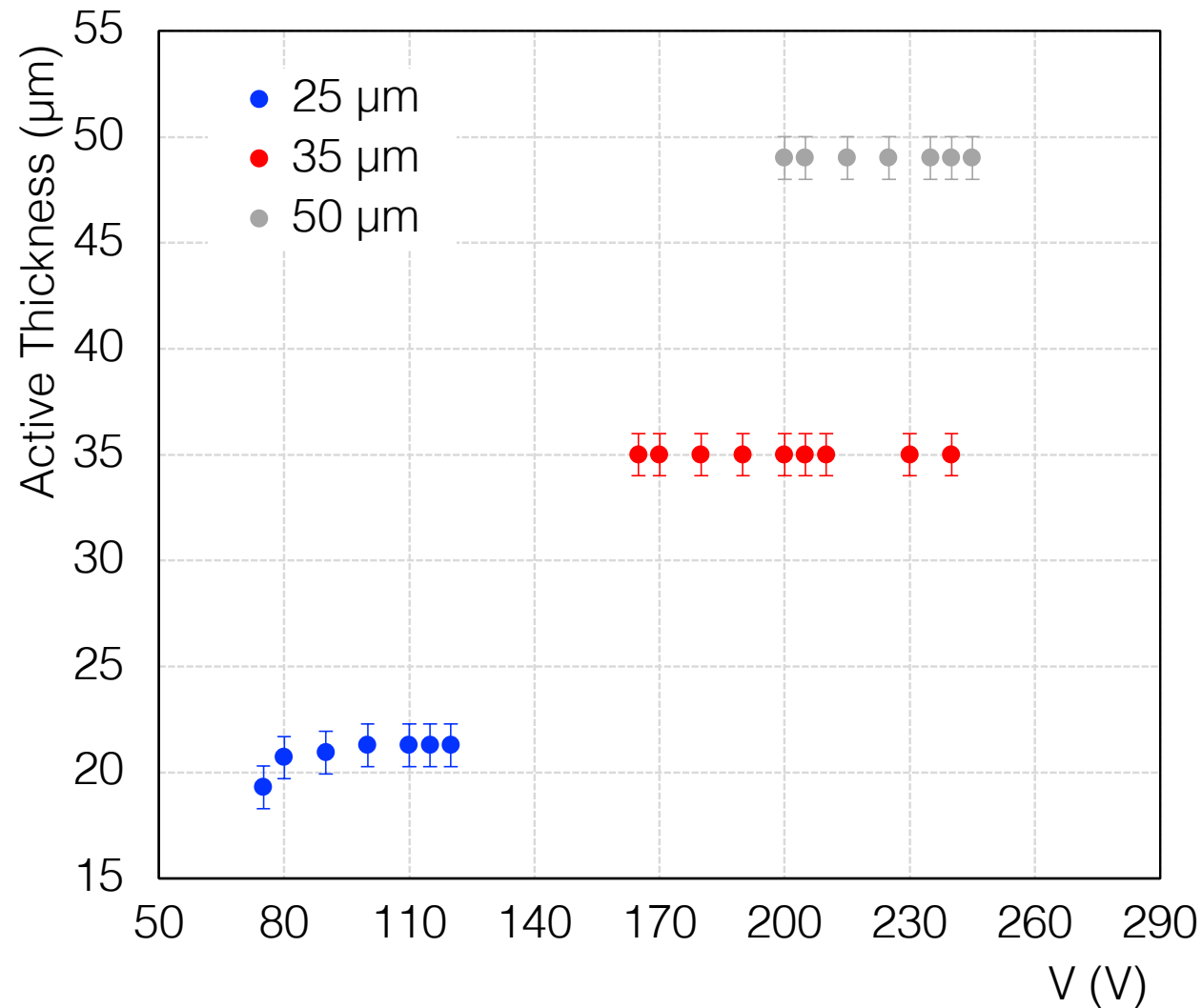
Low resistivity due to high doping of the bulk, which results in a higher E near the junction

- is still depleting and reaches a plateau at around 100V
- lower final active thickness

50 μm , 35 μm

are independent on the V measurements range

→ only info on the total depletion V from CV



ACTIVE THICKNESS

through C-V measurement

25 μm

Low resistivity due to high doping of the bulk, which results in a higher E near the junction

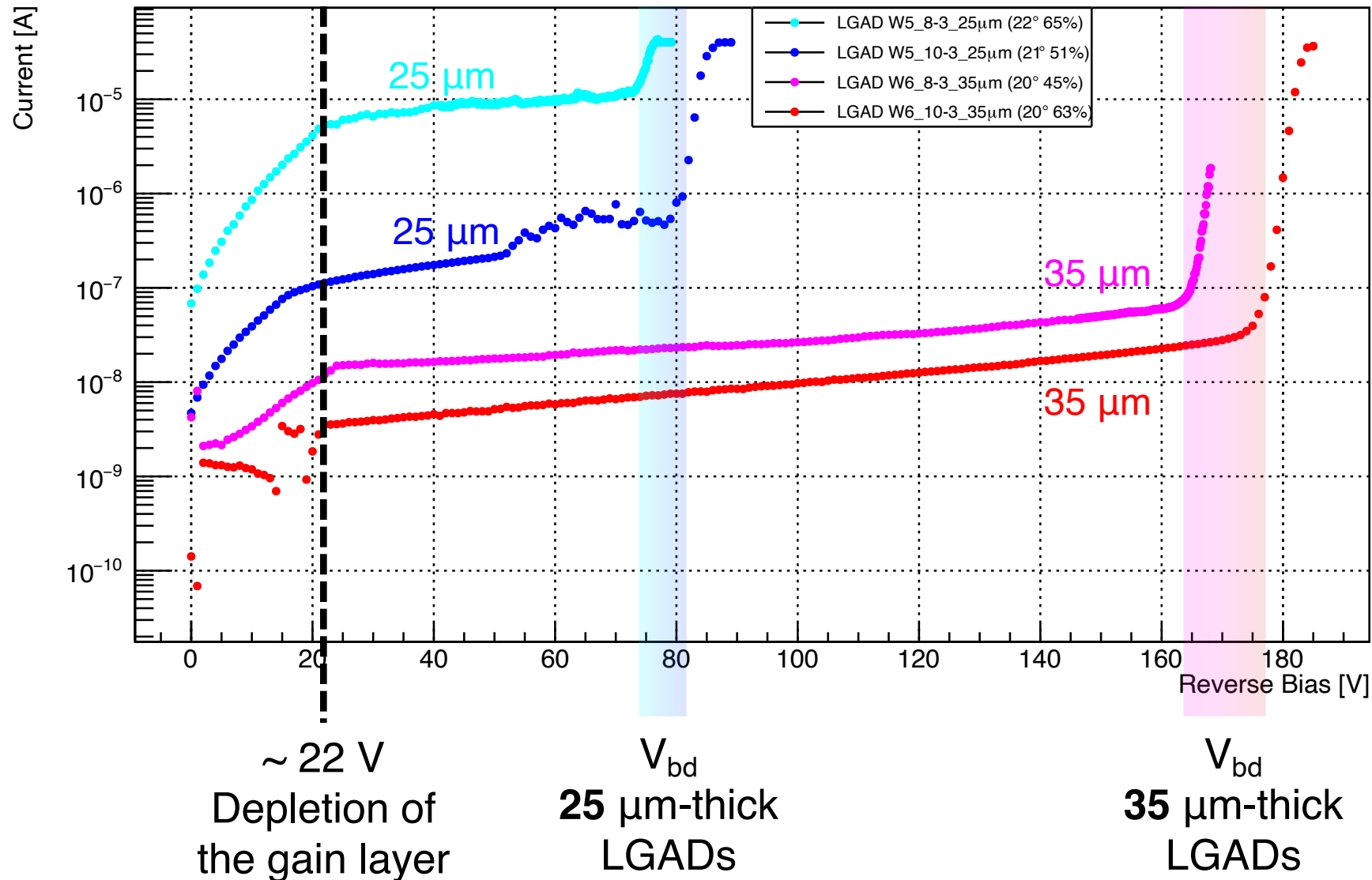
- is still depleting and reaches a plateau at around 100V
- lower final active thickness

50 μm, 35 μm

are independent on the V measurements range

→ only info on the total depletion V from CV

Comparison between 25 and 35 μm -thick LGADs



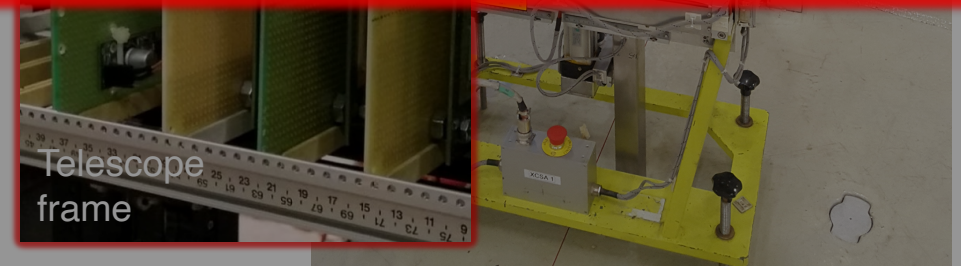
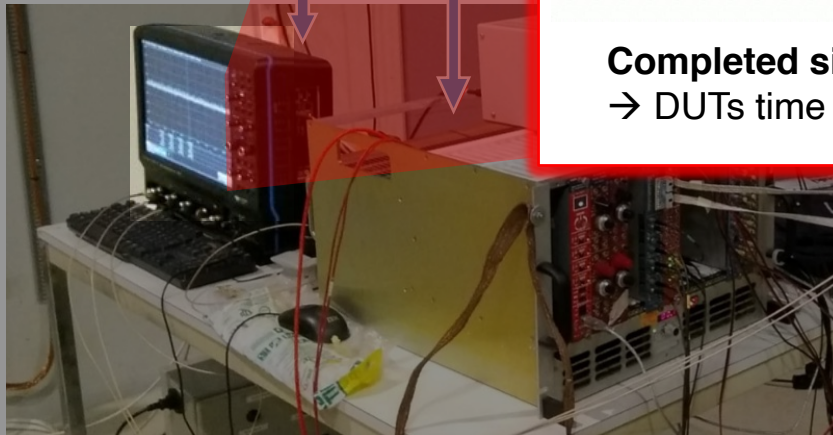
- Breakdown V
- Voltage interval of operation
- Evaluate inter-pad configuration

BEAM
 π 12 GeV/c

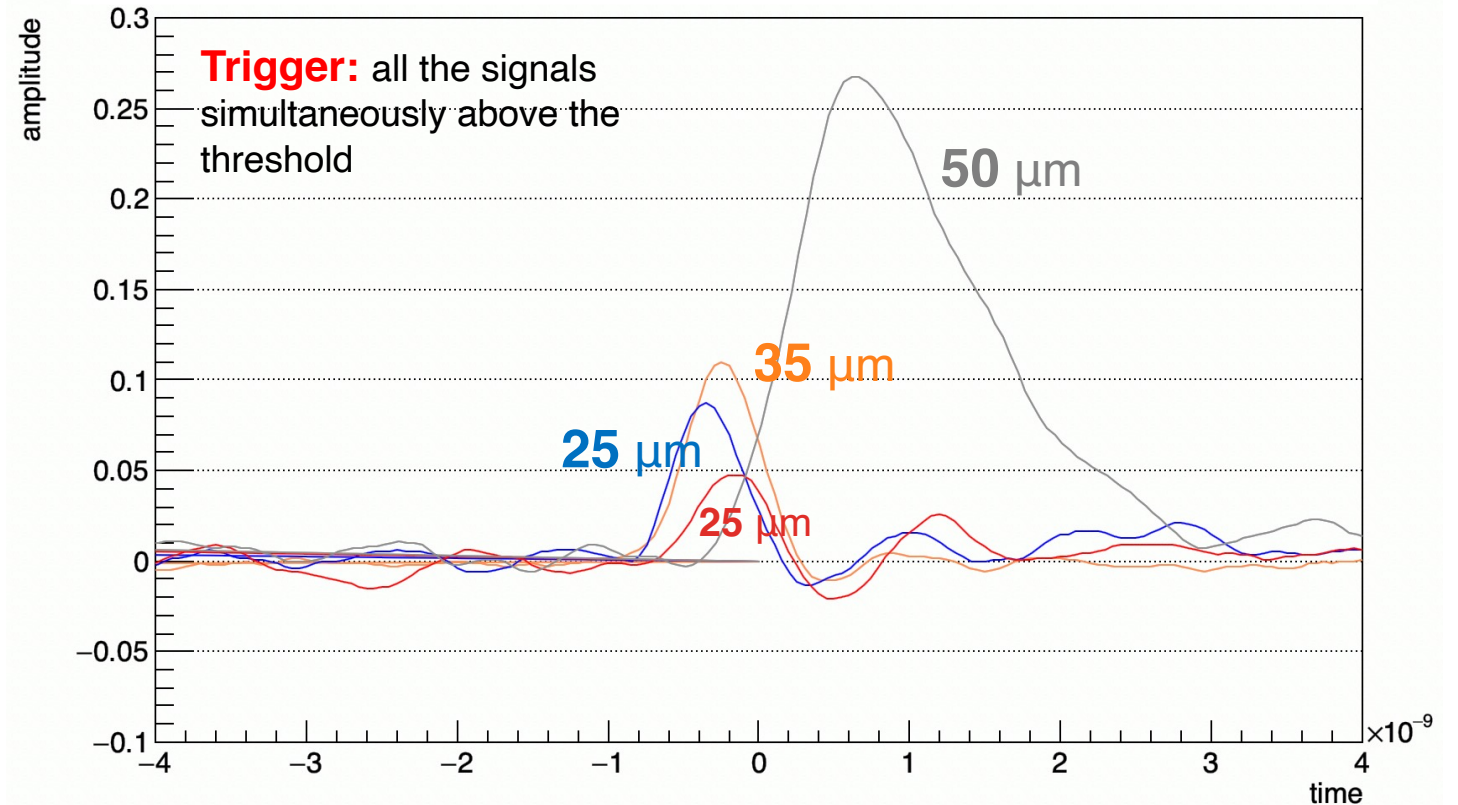
35 μm
LGAD FBK
(1x1 mm²)

25 μm
LGAD
(1x1 mm²)

LeCroy Wave
Sampling
Time disc

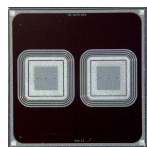


Signal example



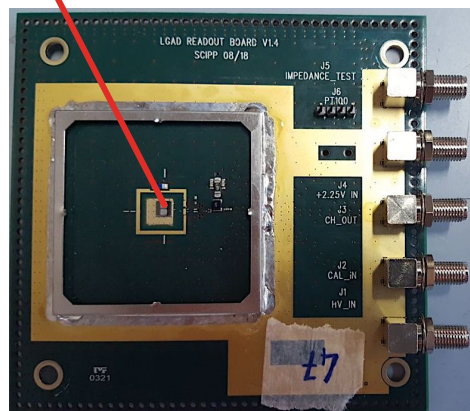
Completed signal waveforms recorded and analyzed offline

→ DUTs time resolutions without problems relates to the front-end electronics



25 μm
35 μm

AMPLIFICATION

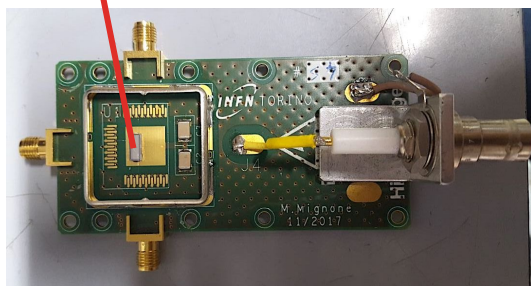


SantaCruz single-channel LGAD read-out board V1.4 SCIPP 08/18
 $G_{\text{amplifier}} \sim 6$

Second stage external amplifier
+ $G_{\text{amplifier}} \sim 13-14$



50 μm



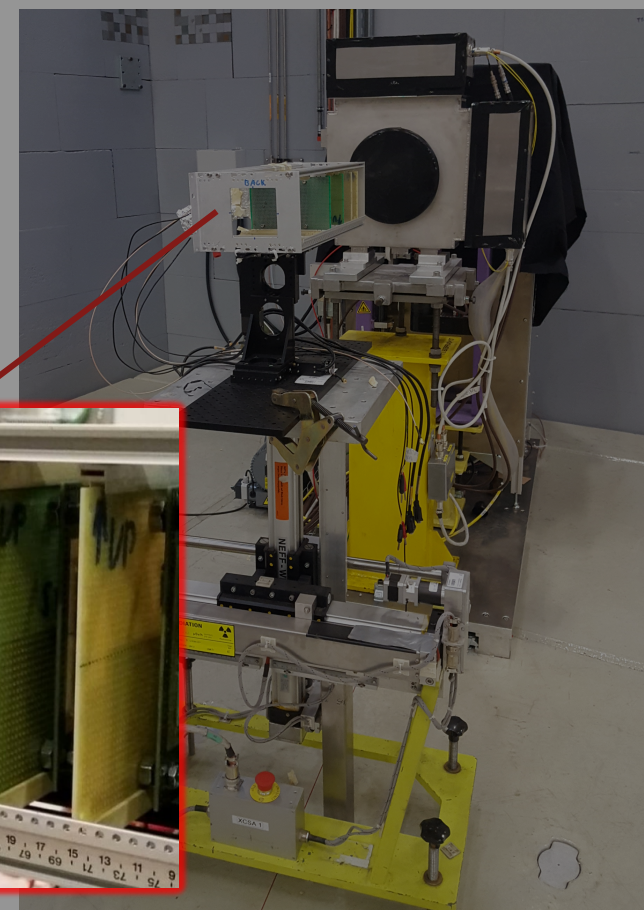
low-noise current amplifier

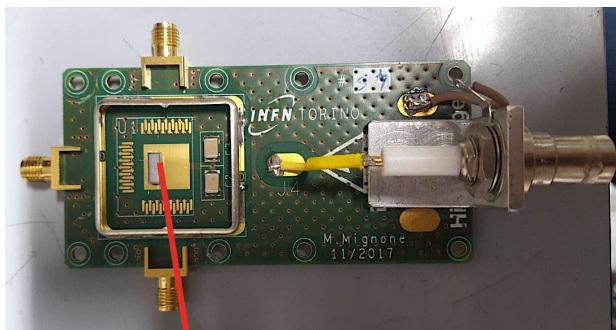
$G_{\text{amplifier}} \sim 196$

TEST BEAM SETUP

50 μm

LGAD HPK
(1x3 mm²)



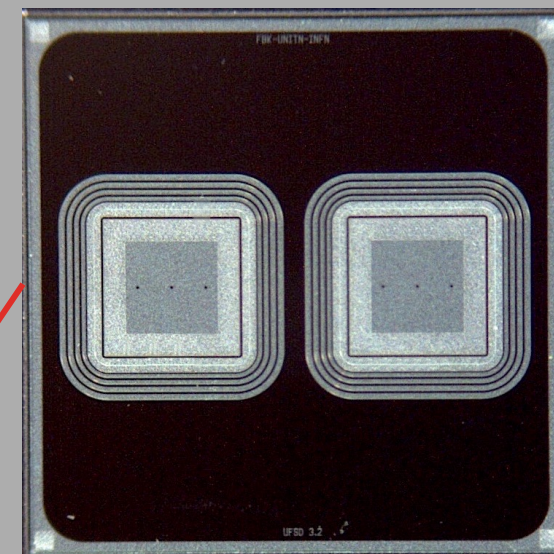


low-noise current amplifier

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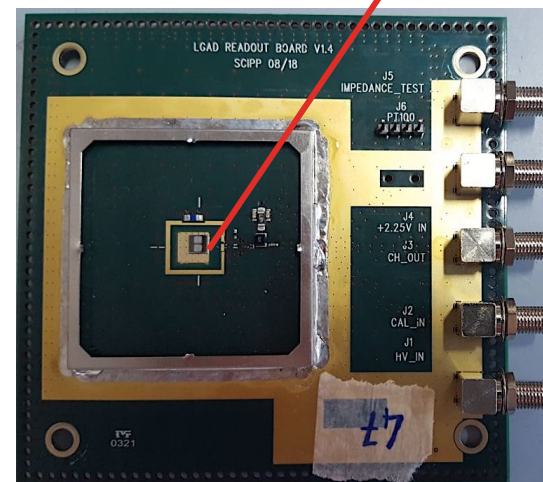
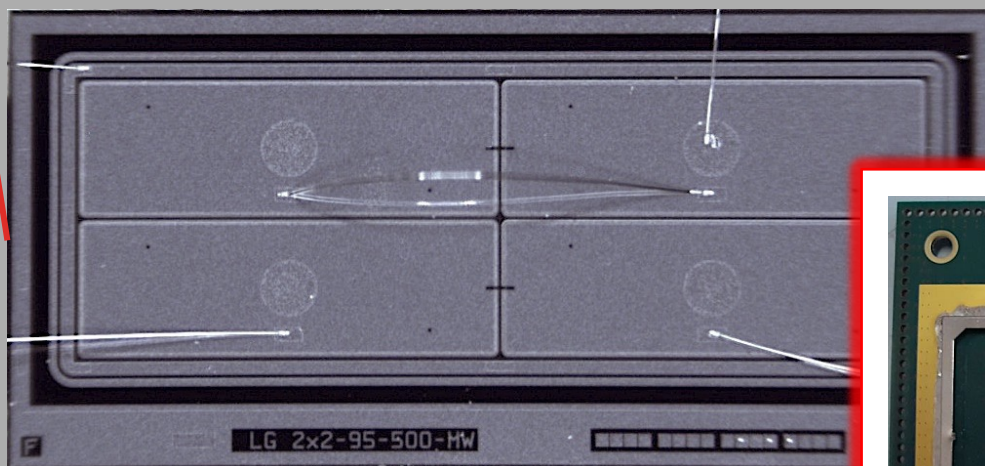
First very thin LGAD prototypes produced by FBK

25 μm and
35 μm -thick FBK
single channel



50 μm -thick HPK LGAD

1x3 mm²



SantaCruz
single-channel LGAD
read-out board V1.4
SCIPP 08/18

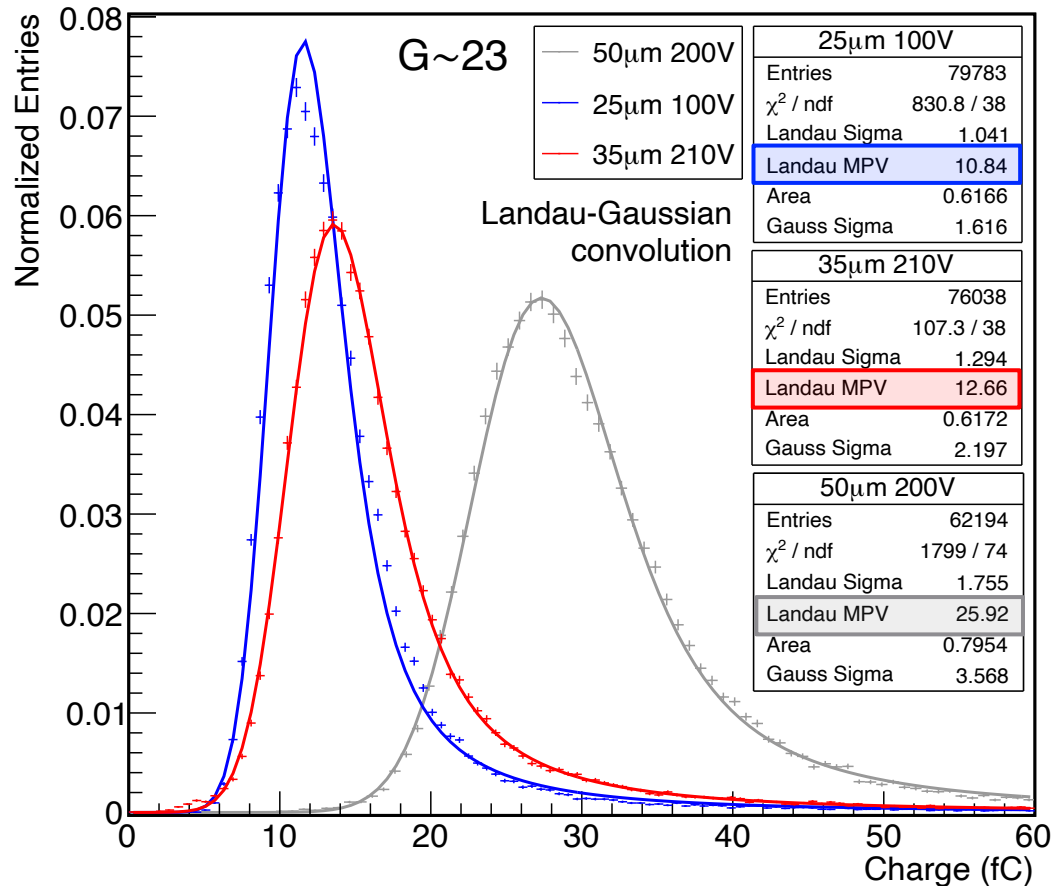
$G_{\text{amplifier}} \sim 6$

Second stage external amplifier

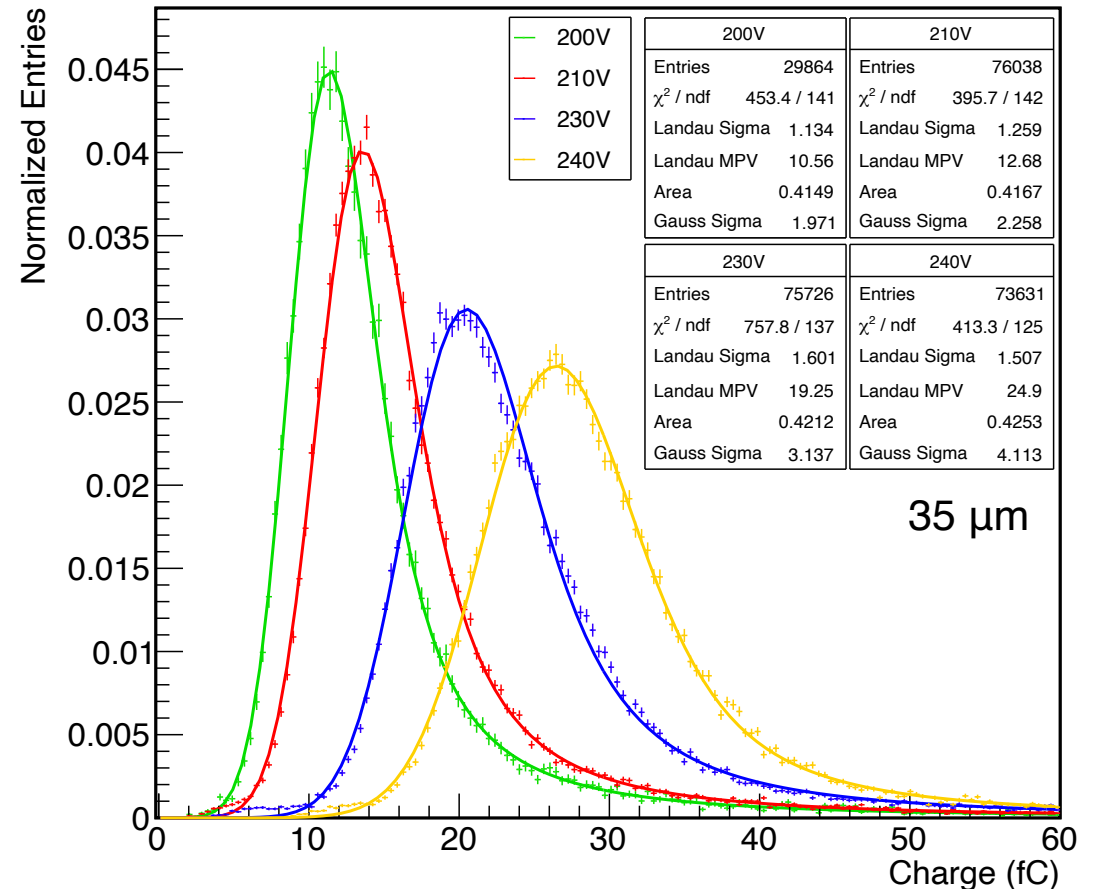
$G_{\text{amplifier}} \sim 13-14$

CHARGE DISTRIBUTIONS

Charge MPV increases →



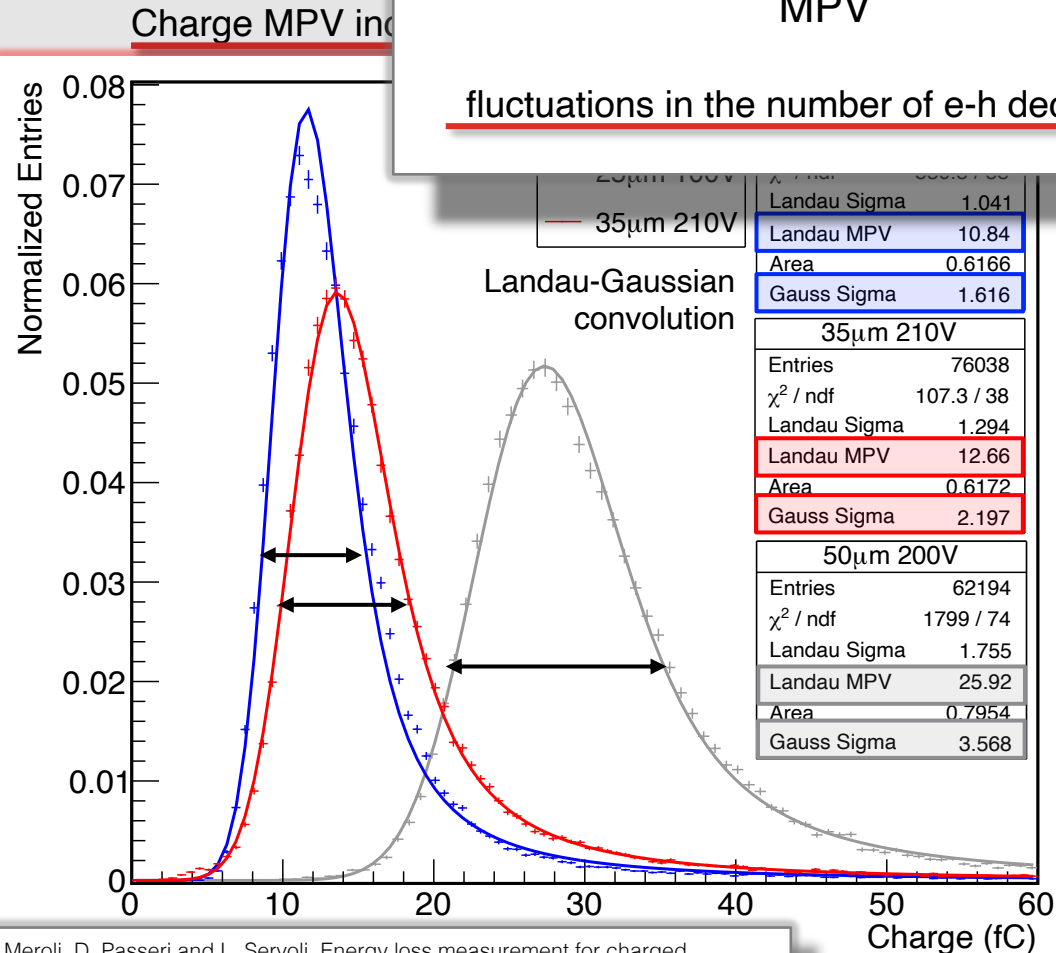
Charge MPV increases →



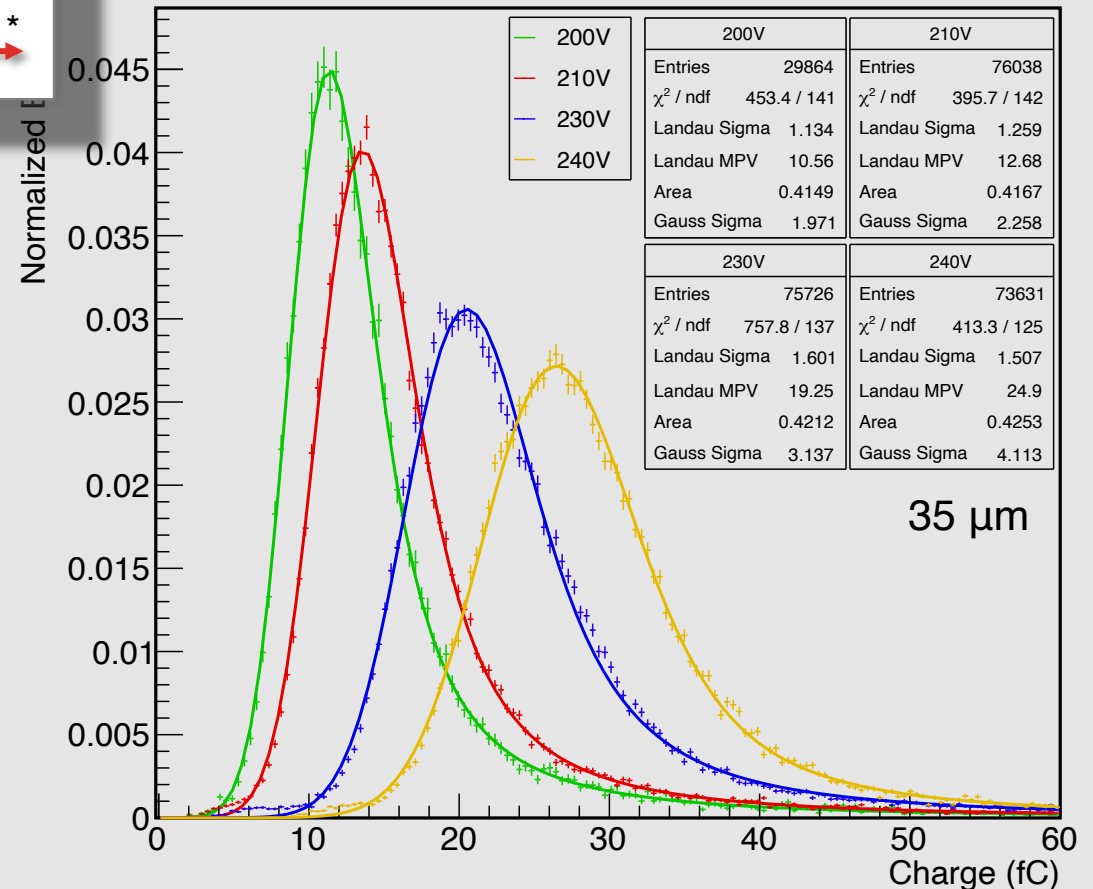
CHARGE DISTRIBUTIONS

Width of the distribution
MPV

fluctuations in the number of e-h decreases *



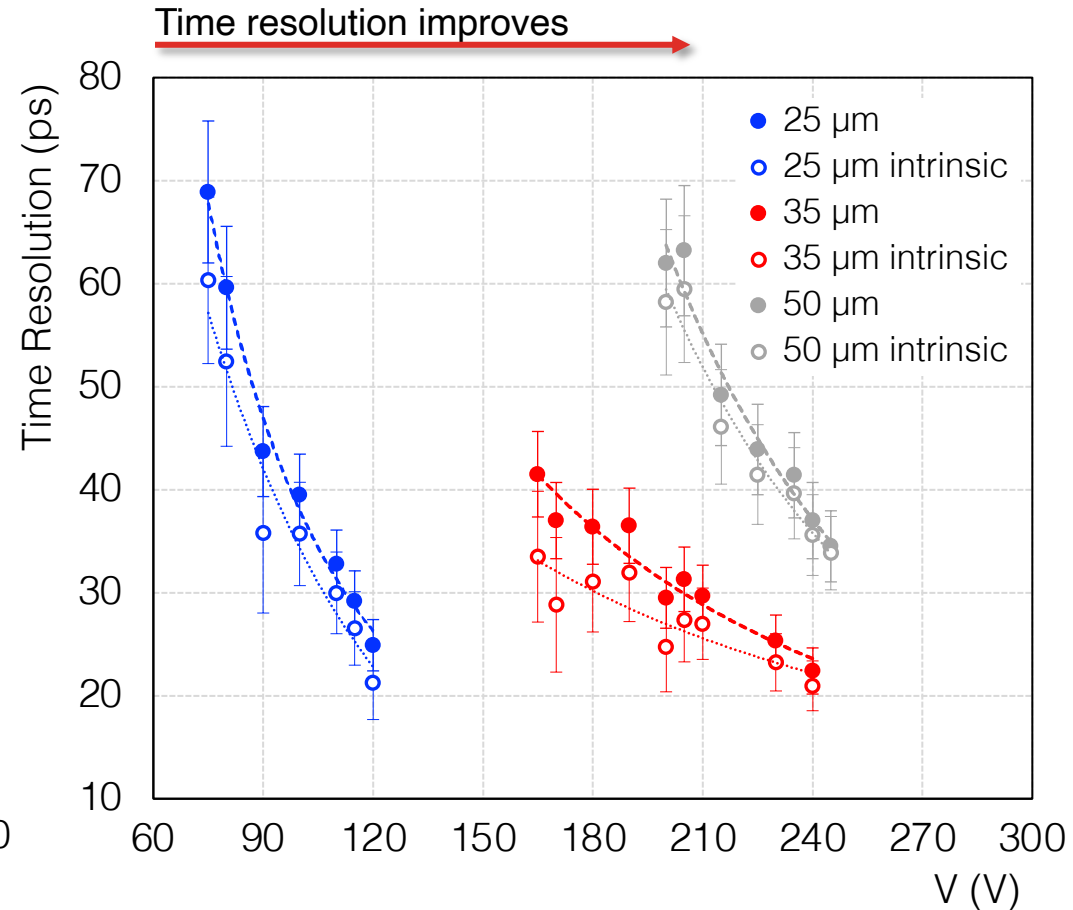
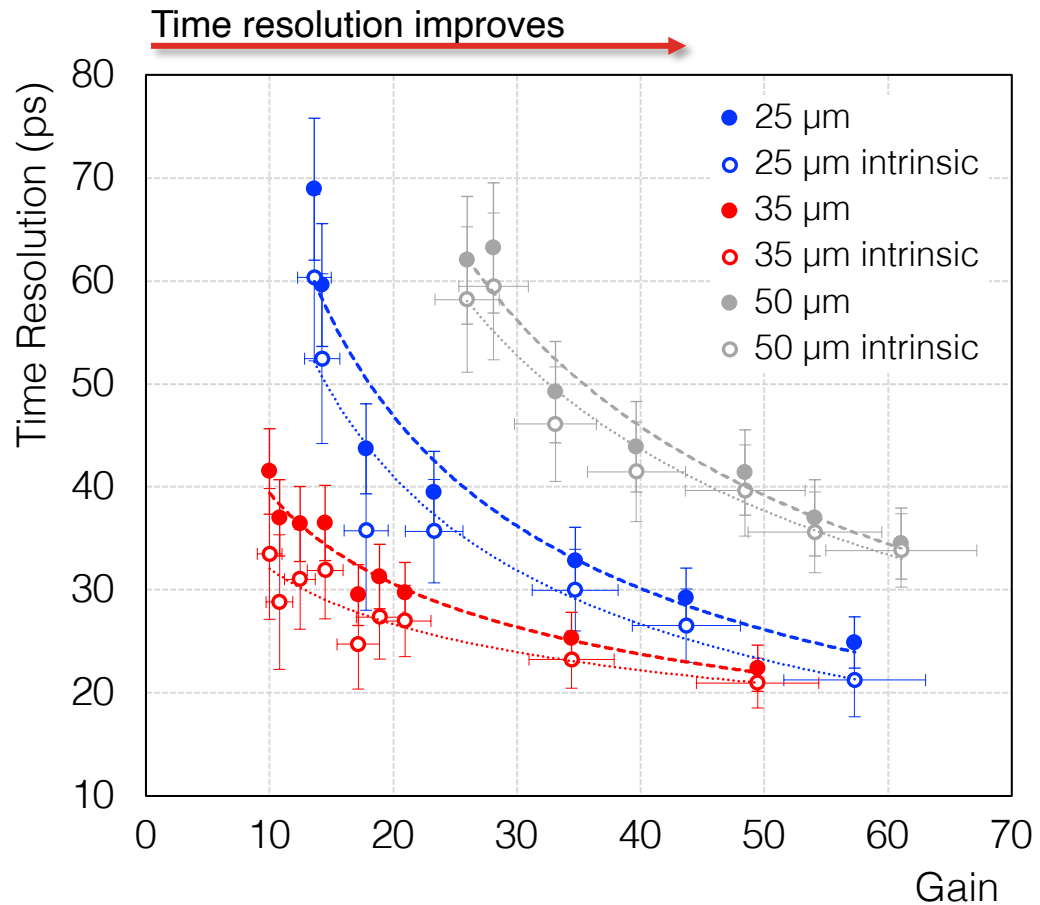
Charge MPV increases



* S. Meroli, D. Passeri and L. Servoli, Energy loss measurement for charged particles in very thin silicon layers <https://doi.org/10.1088/1748-0221/6/06/p06013>
W. Riegler and G. Aglieri Rinella, Time resolution of silicon pixel sensors <https://doi.org/10.1088/1748-0221/12/11/p11017>

TIMING PERFORMANCES

- 50 μm LGAD $\rightarrow$ ~ 34 ps confirms previous results
- Better values for thinner detectors ($\searrow$ Landau term)
- 25 & 35 μm are compatible within the uncertainties ~ 25 ps & 22 ps
 - $\rightarrow$ worse S/N, not optimized wafer production



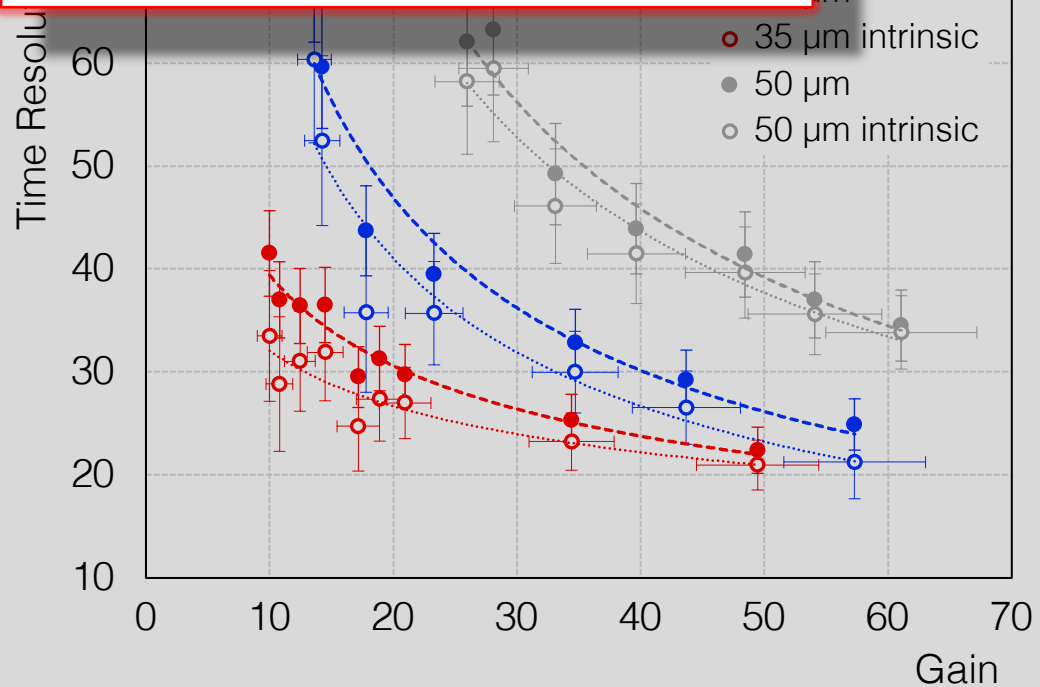
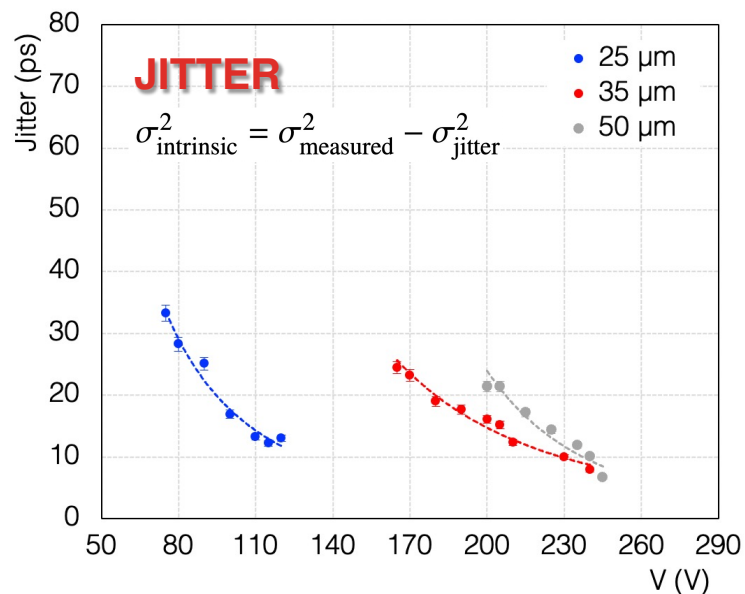
PERFORMANCES

previous results

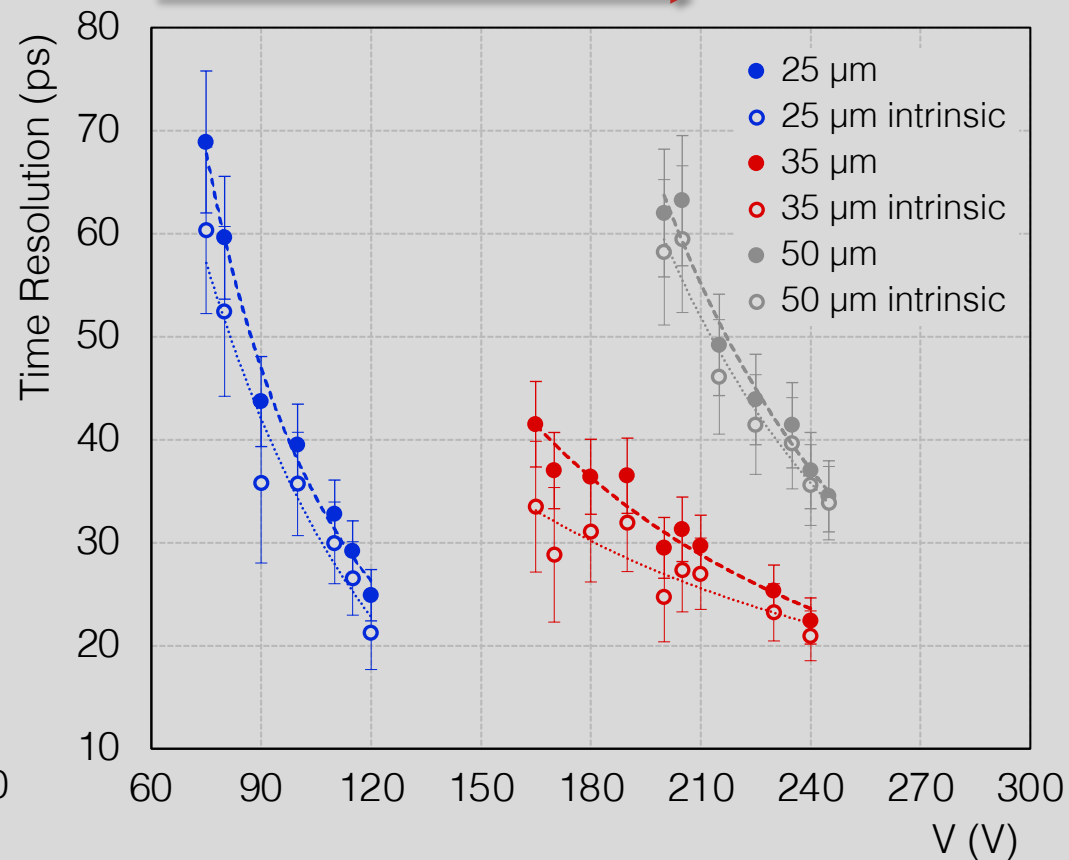
($\propto$ Landau term)

the uncertainties ~ 25 ps & 22 ps

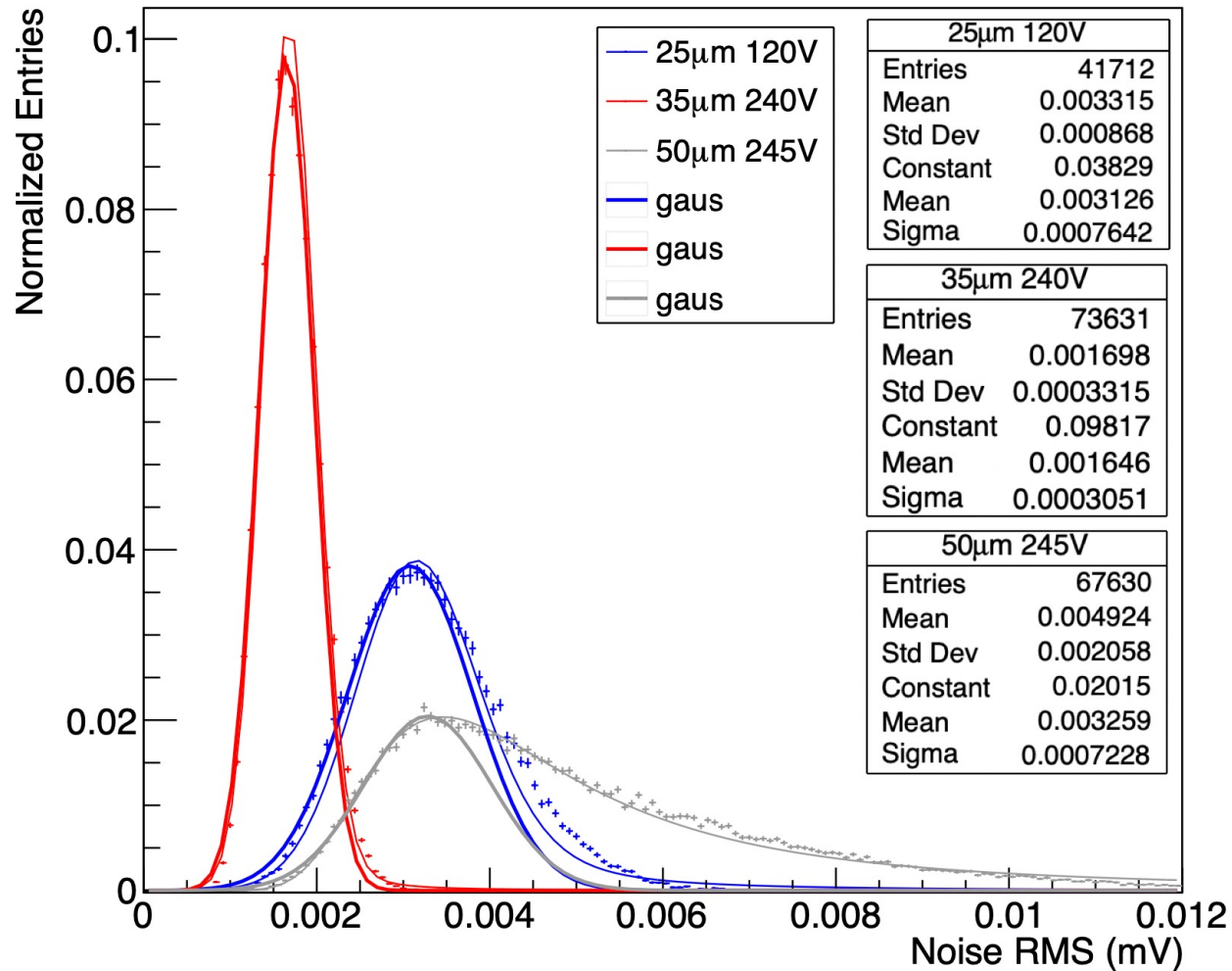
duction



Time resolution improves

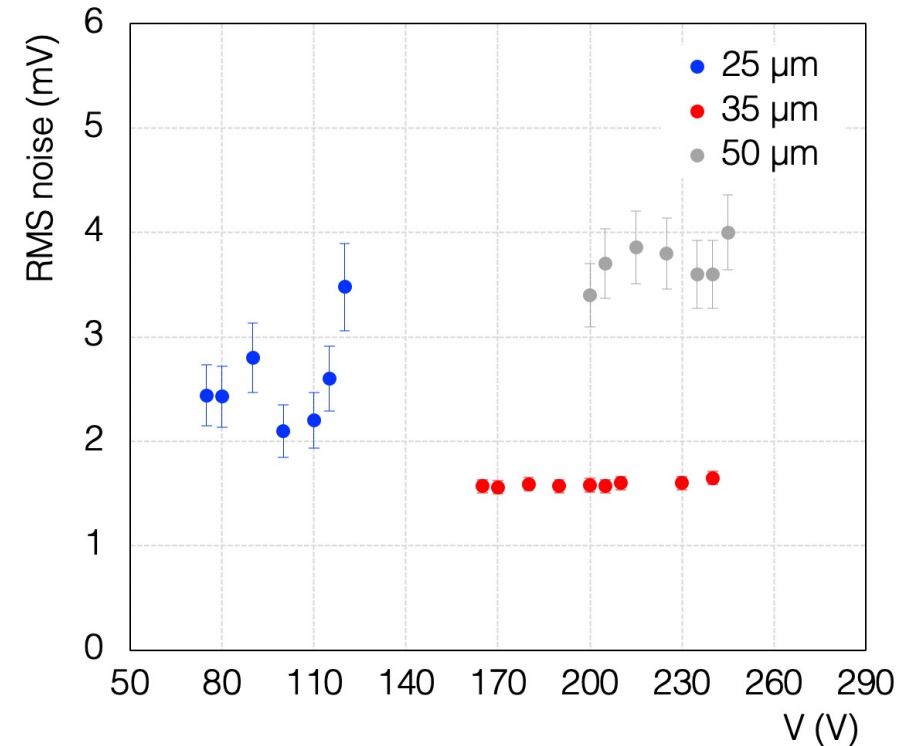


NOISE RMS



Extracted considering a time window before the signals

- More Gaussian distribution for the thinner sensors
- Lower for the **35 μm** LGAD
- Stable MPV between 1-4 mV



50 μm (reference) sensor in line with expectations $\rightarrow$ 34 ps

- Experimental setup and analysis procedure have been validated

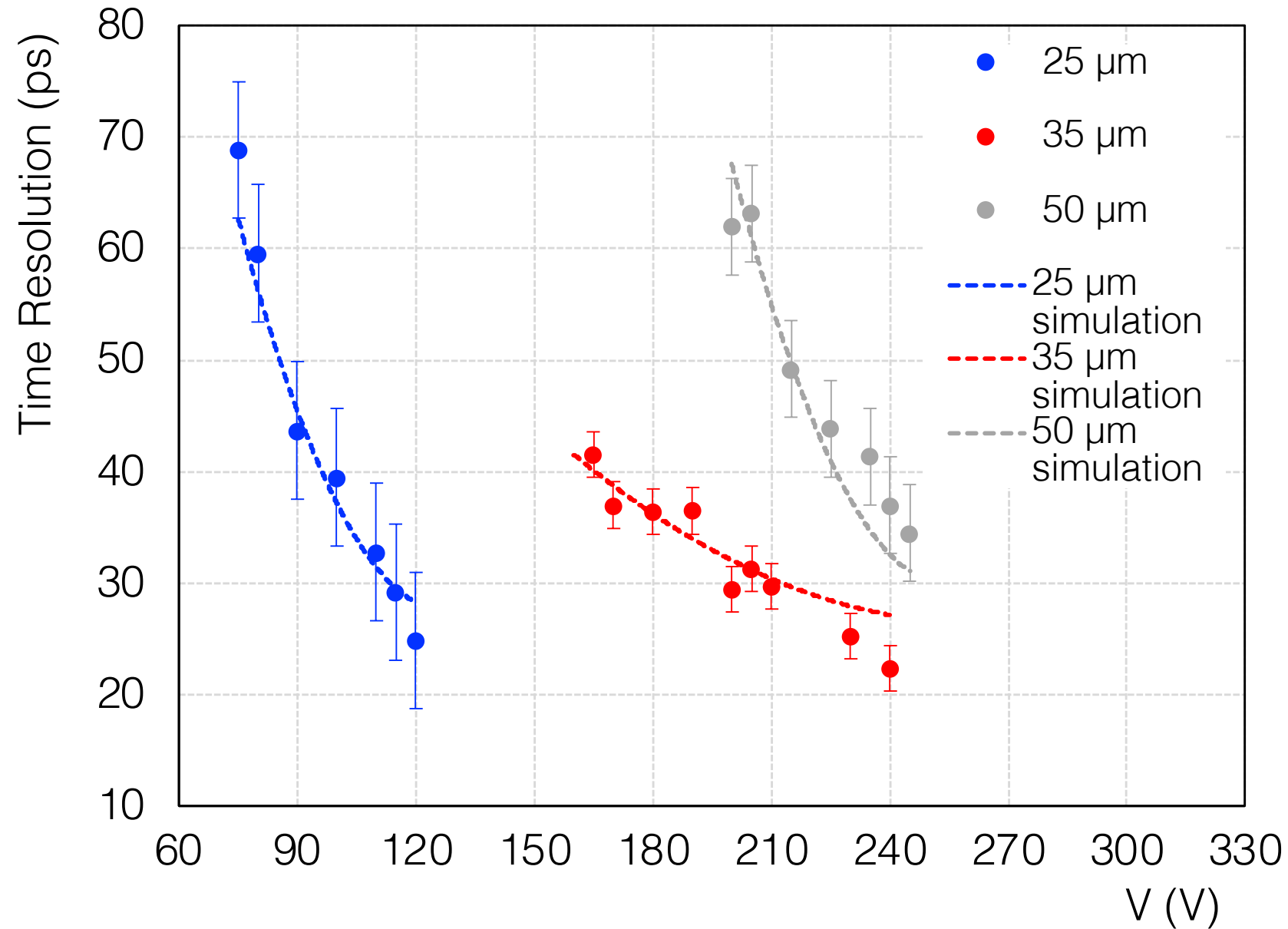
Thinner detectors:

- 25 μm $\rightarrow$ 25 ps at 120V
 - Slightly worse than simulations (maybe due to fabrication design)
- 35 μm $\rightarrow$ 22 ps at 240V
 - in agreement with MC simulations
- Both $\rightarrow$ Improved time resolution with thinner LGAD detectors

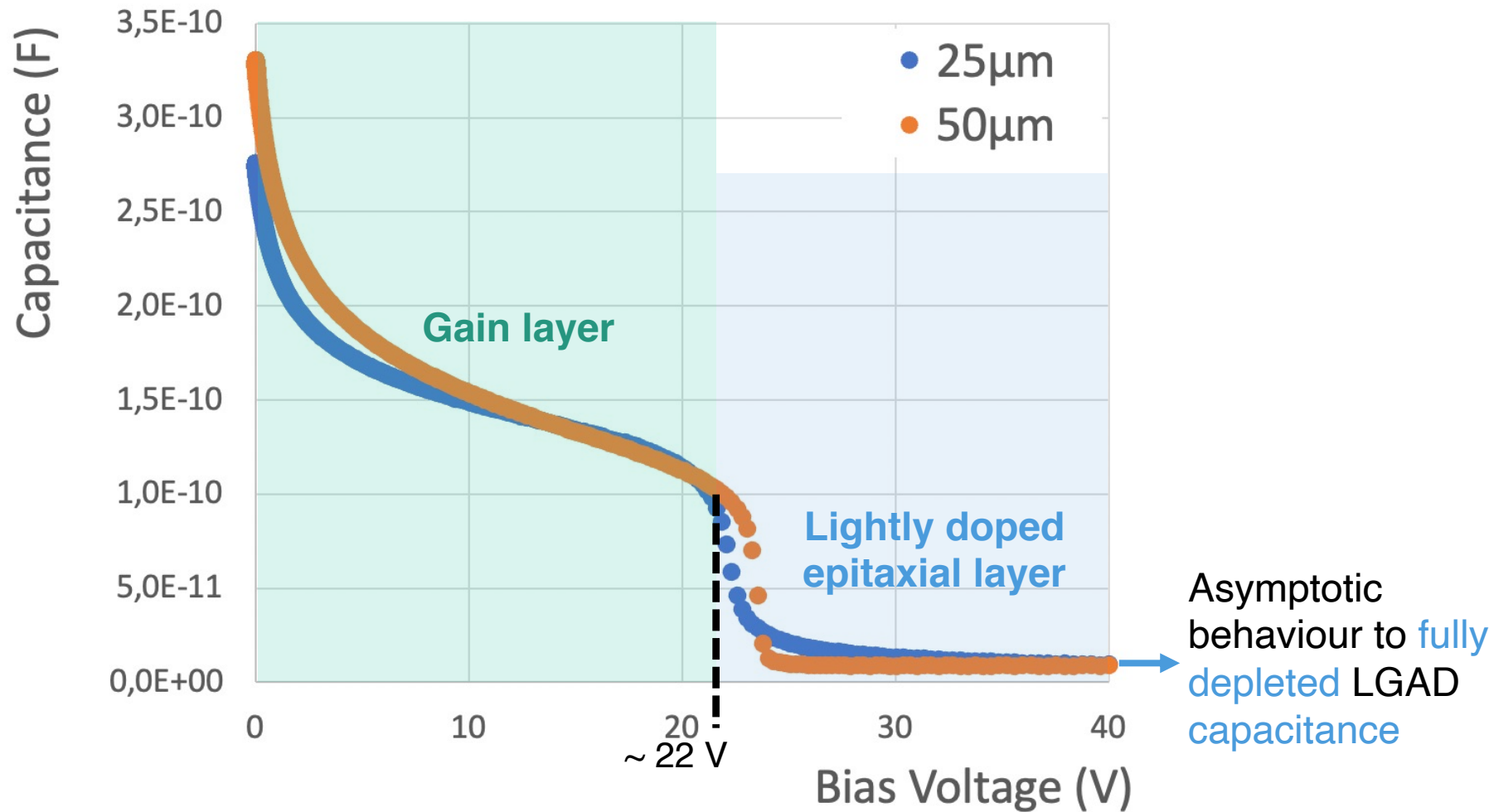
FUTURE PLANS

- We are in contact with FBK to continue the R&D focused on the design of LGADs optimized for the TOF system requirements
 - Validate the results on 25 μm
 - $\rightarrow$ maybe considering a new production with the **right doping concentrations**
 - Eventually study the timing performance of **even thinner sensors**
- Beam tests 2022
 - Two slots in July and November

WEIGHTFIELD SIMULATIONS



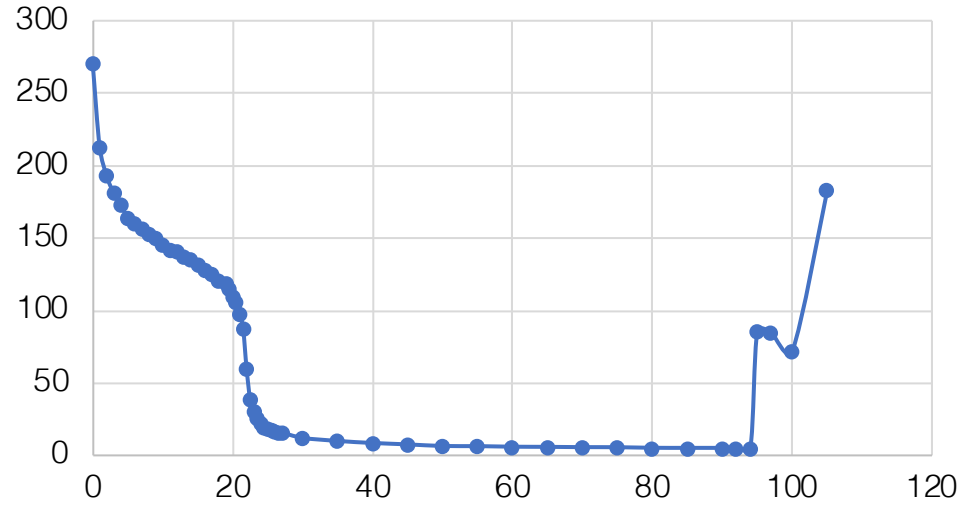
CV example for 25 and 50 μm -thick LGADs



- Gain layer depletion V
- Full depletion V
- Connected to the doping profile

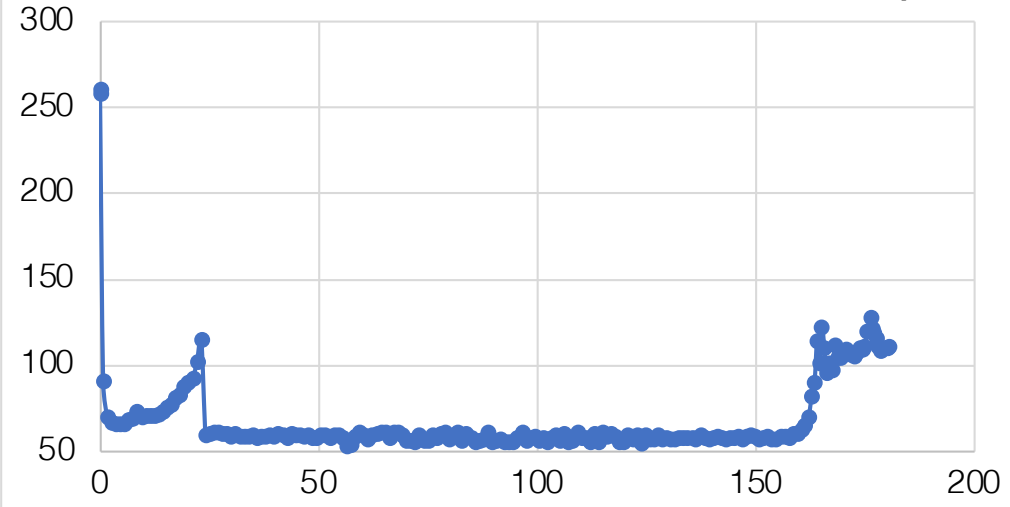
C (pF)

25 μm



C (pF)

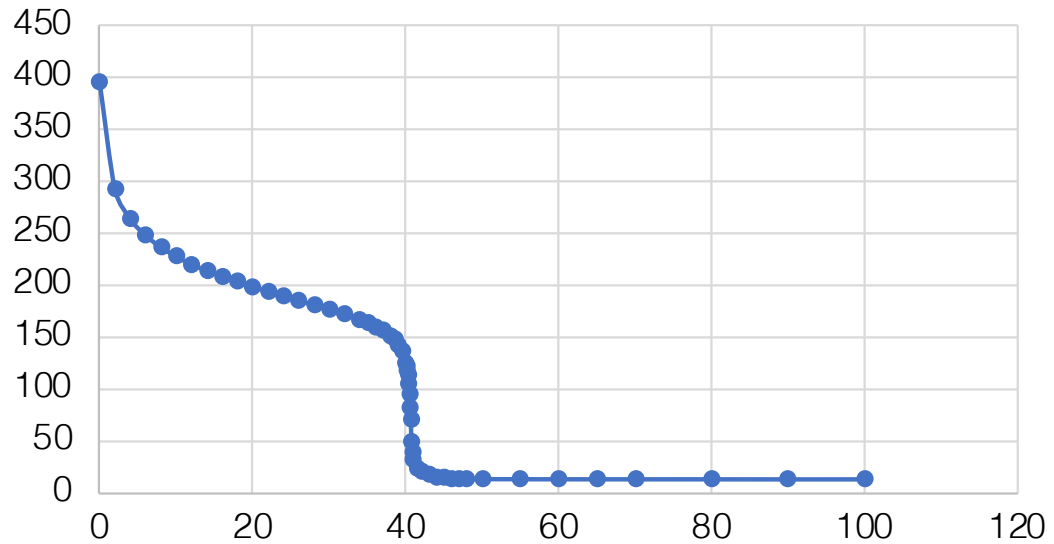
35 μm



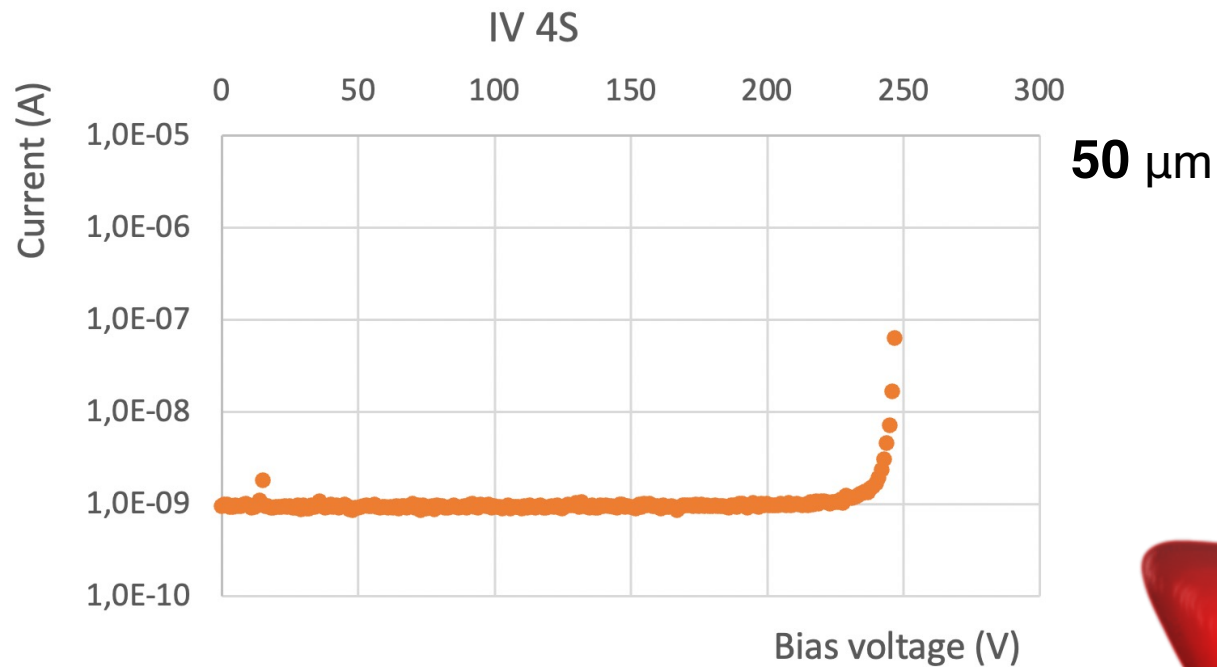
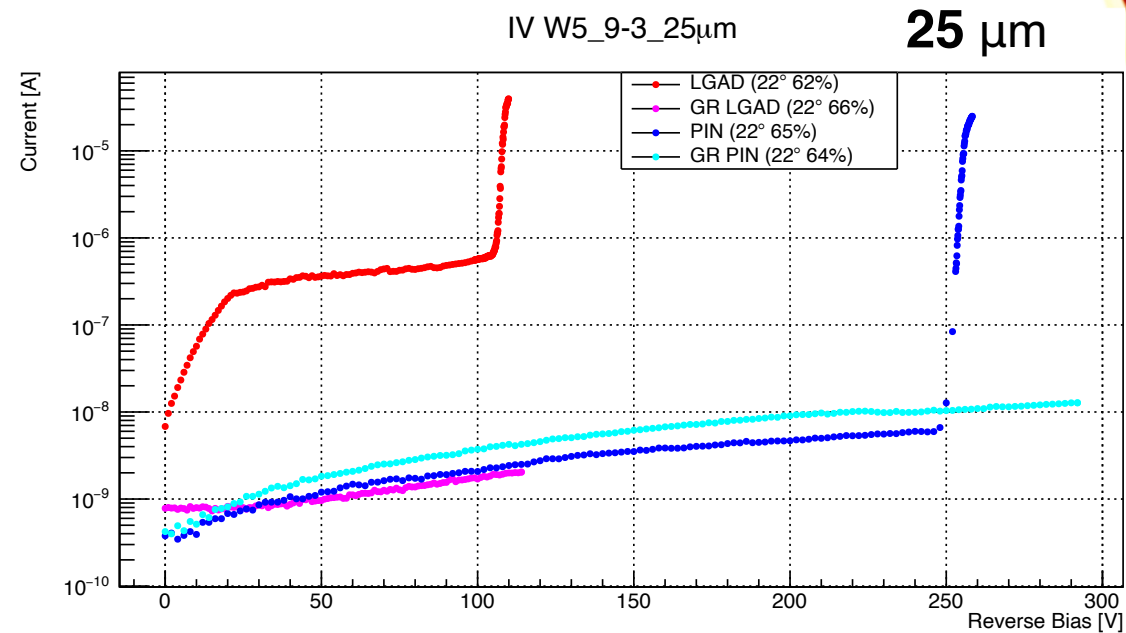
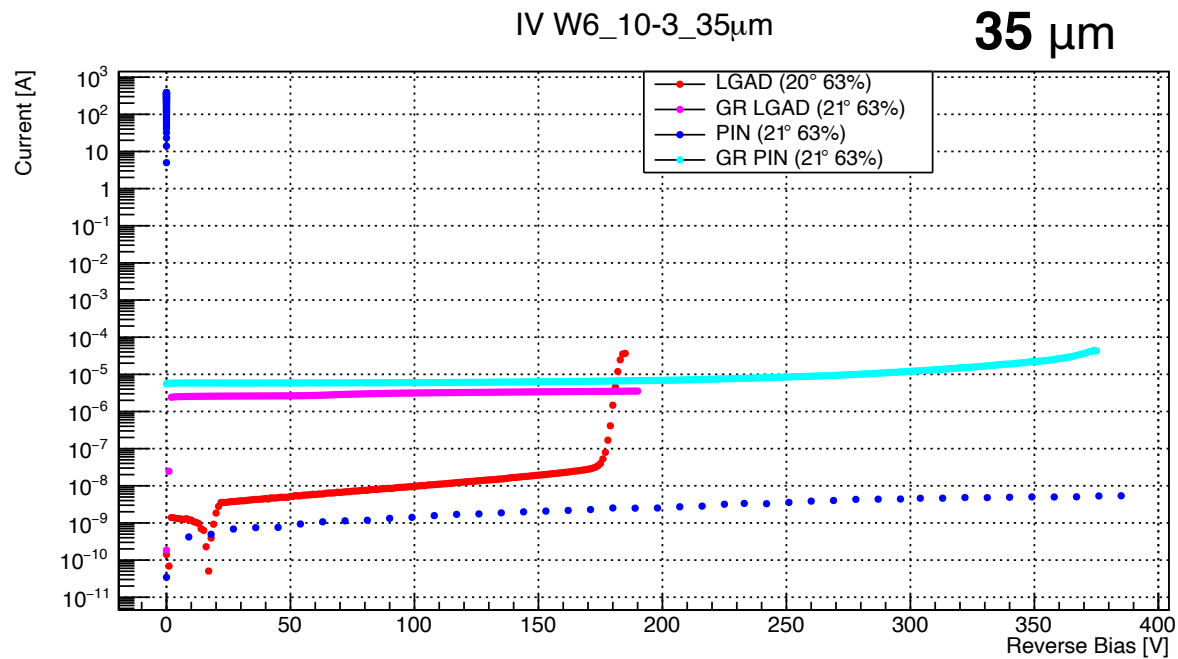
CAPACITANCE- VOLTAGE CHARACTERISTICS

C (pF)

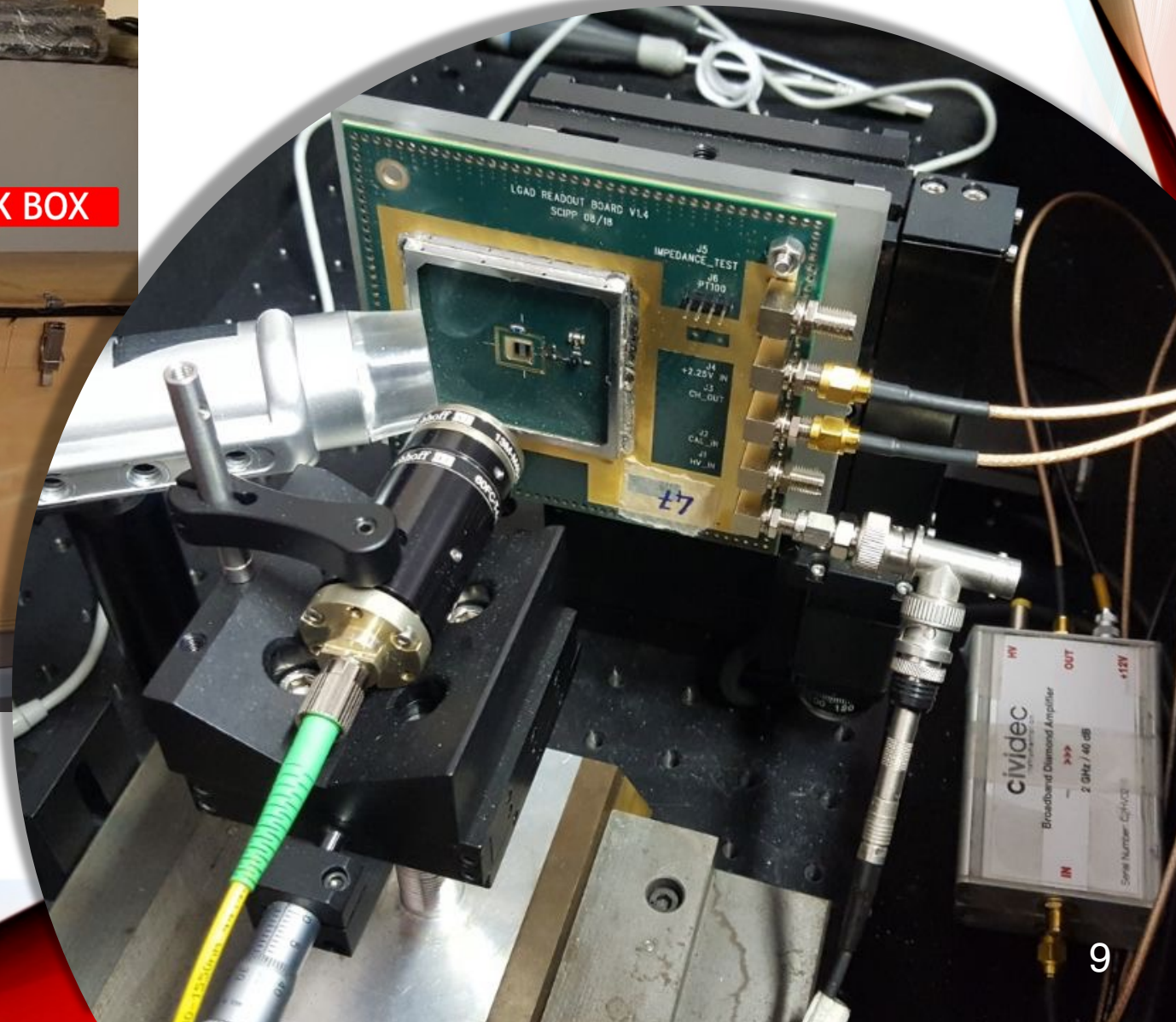
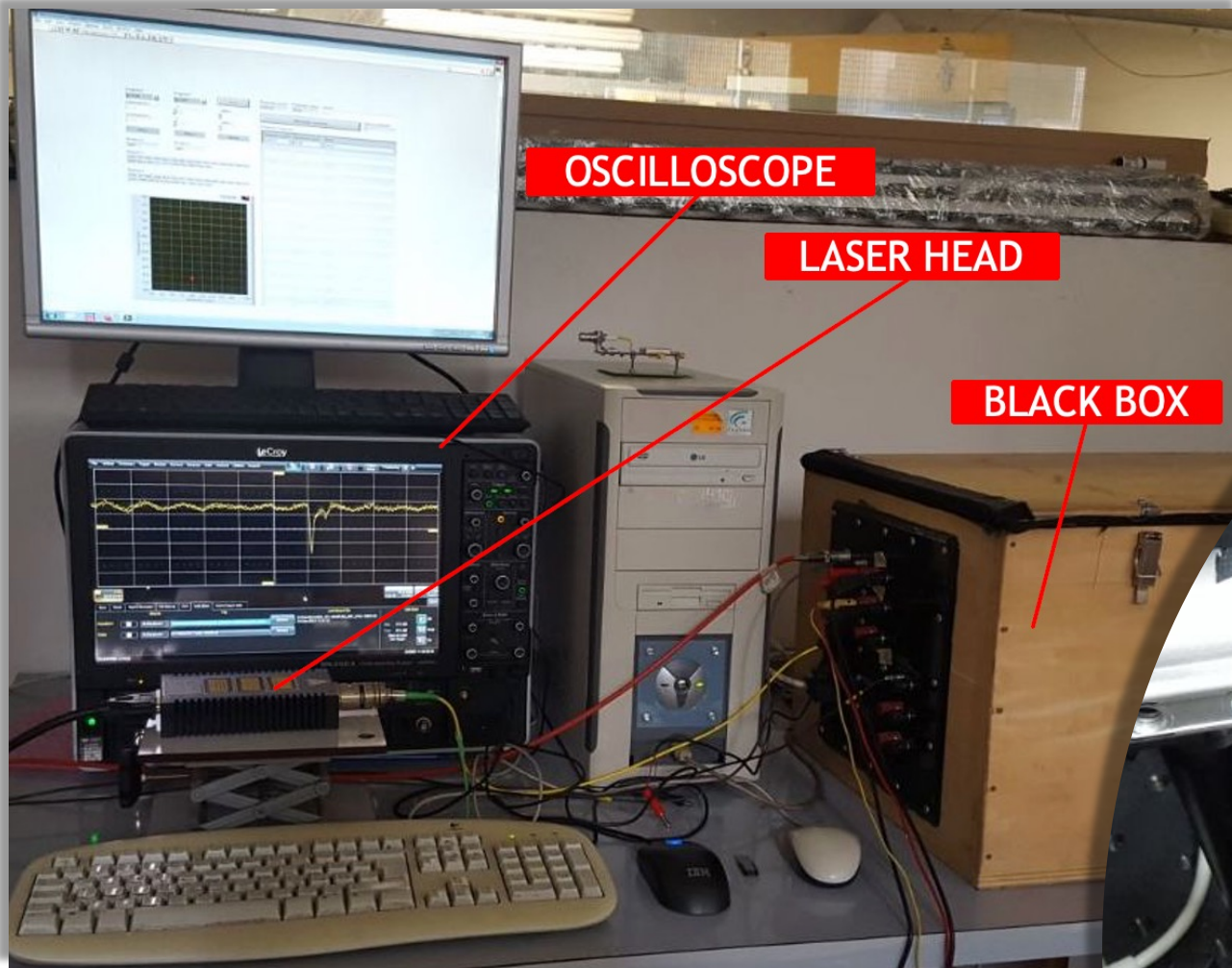
50 μm



CURRENT-VOLTAGE CHARACTERISTICS

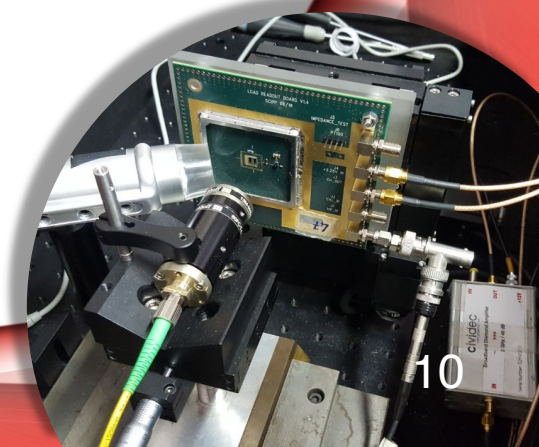
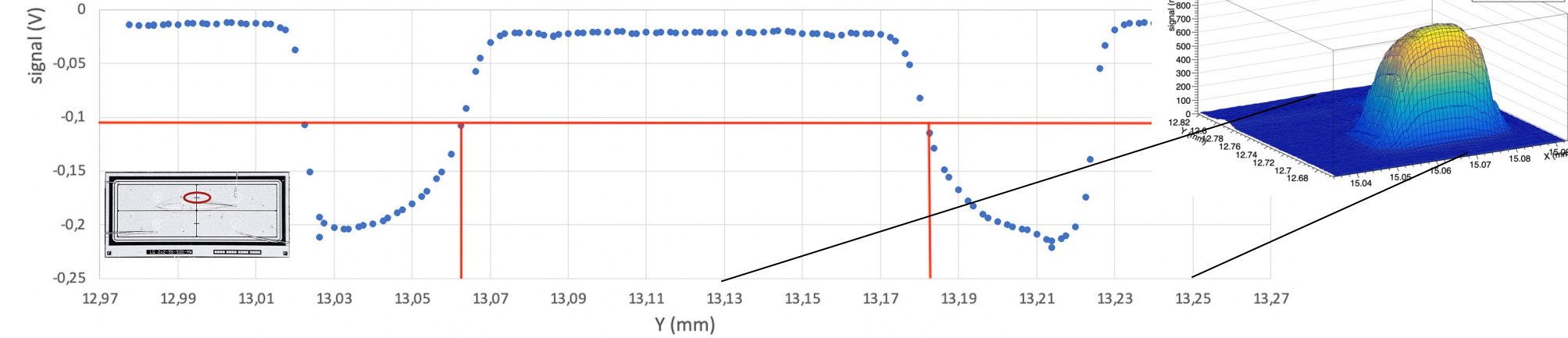
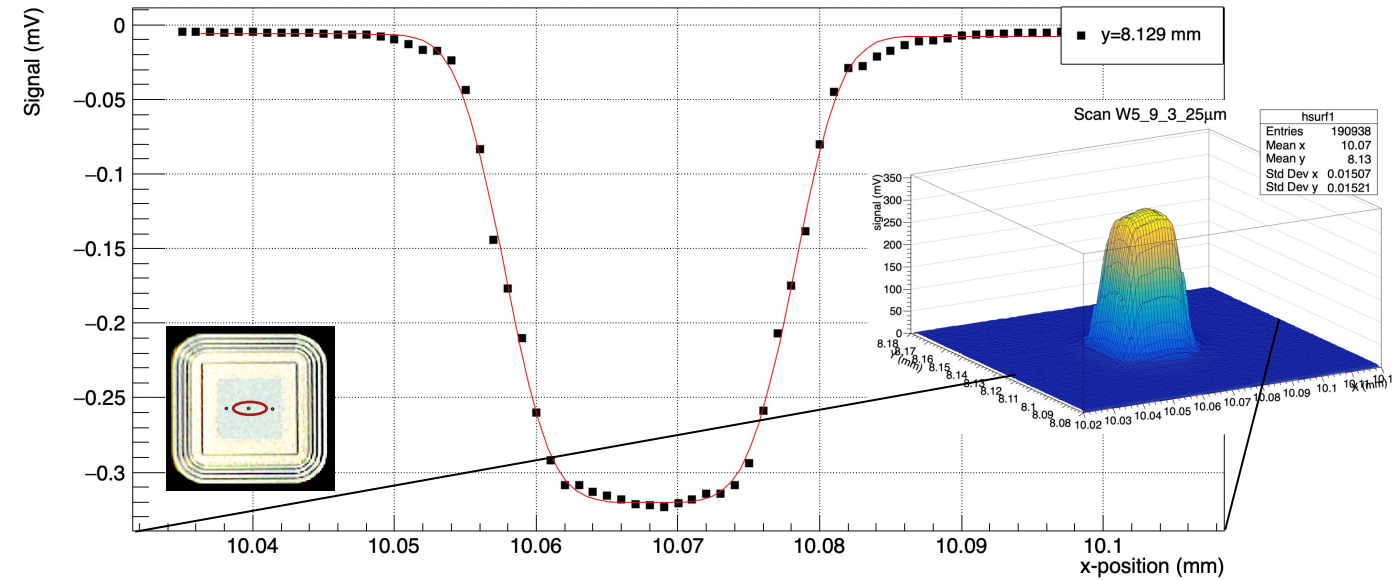


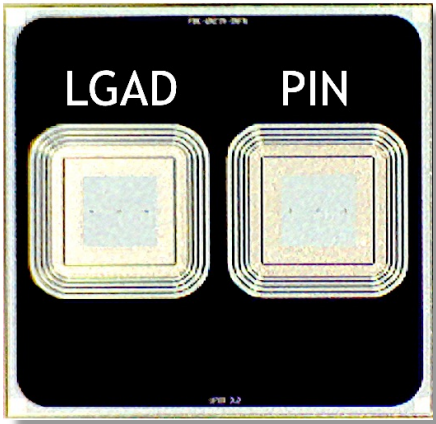
PERFORMANCES STUDY



PRELIMINARY TESTS through automatic scans

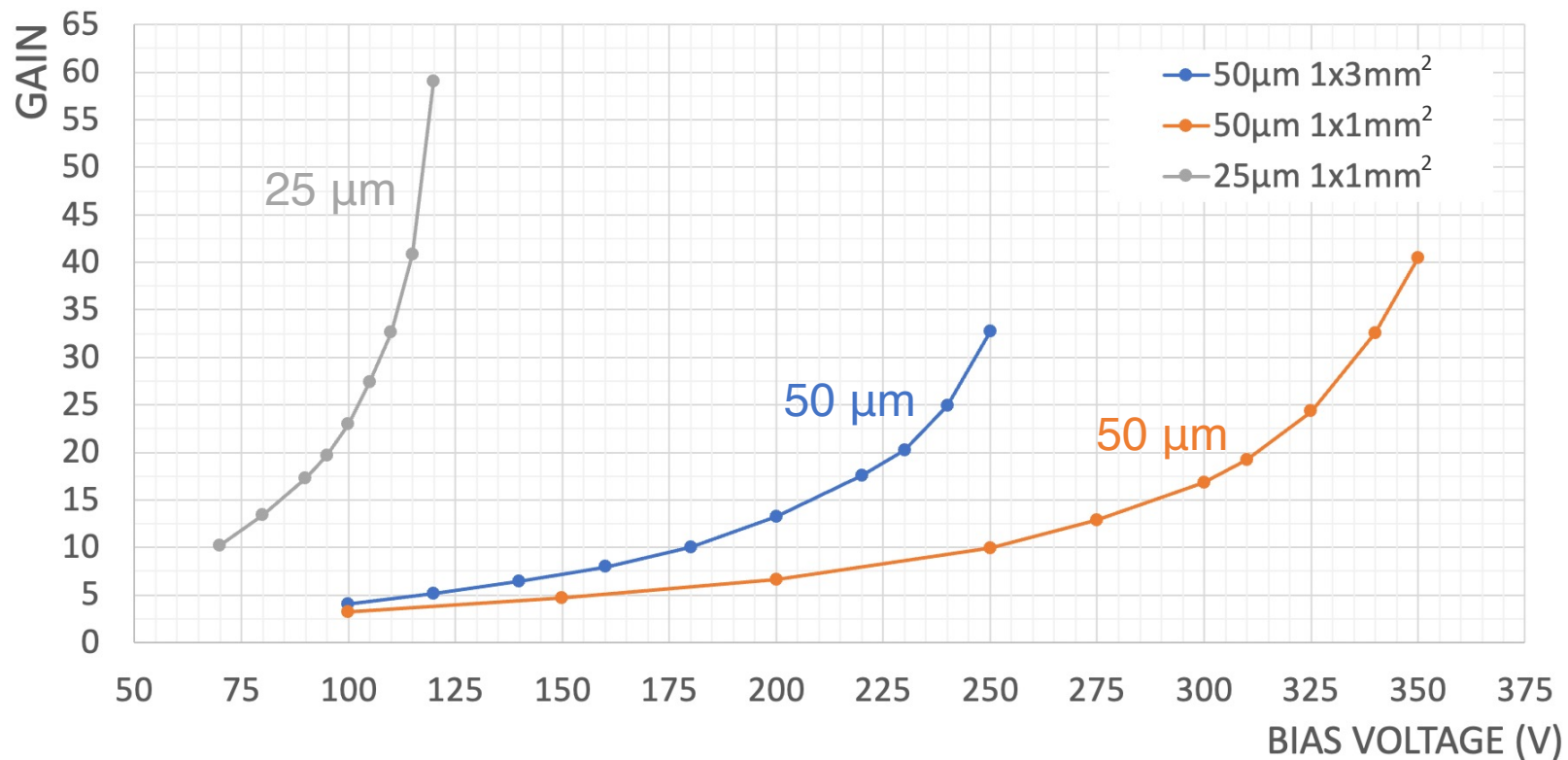
- Evaluate light sensitive areas
 - Efficiency
 - Uniformity
 - Edge effects
- Extract windows and laser spot dimensions





Same { Light conditions
Focusing of the spot

$$G = \frac{\text{mean charge of the LGAD}}{\text{mean charge in the reference PIN (without gain)}}$$



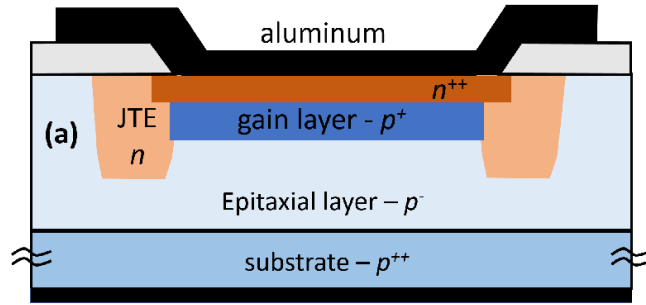
GAIN EVALUATION

Related to time resolution



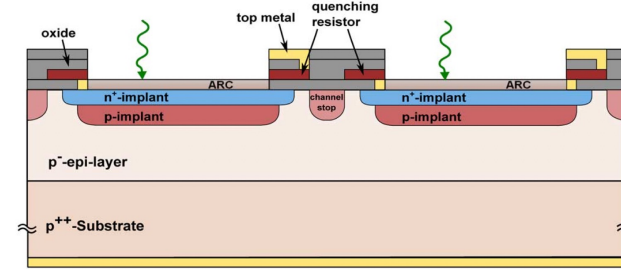
Voltage in which to operate the LGAD

NEW SILICON TECHNOLOGIES



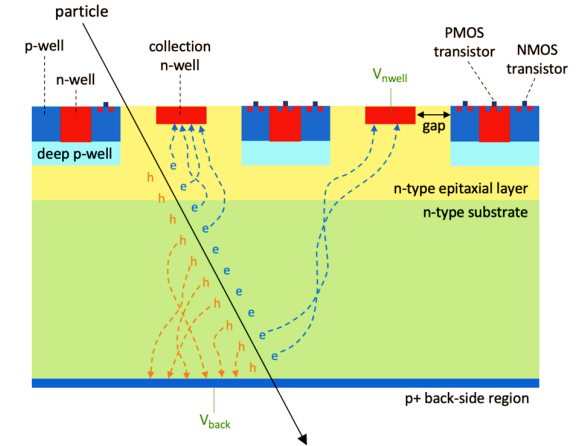
LGAD

- 30-35 ps for 50 μm up to $(1-2)10^{15}$ 1-MeV- $n_{\text{eq}}/\text{cm}^2$
- Recent Simulations with thinner design
→ **20 ps**



SiPM

- Only for photon detection so far
→ ~ 20 ps
- **Investigation with charged particles**
→ already started in Bologna



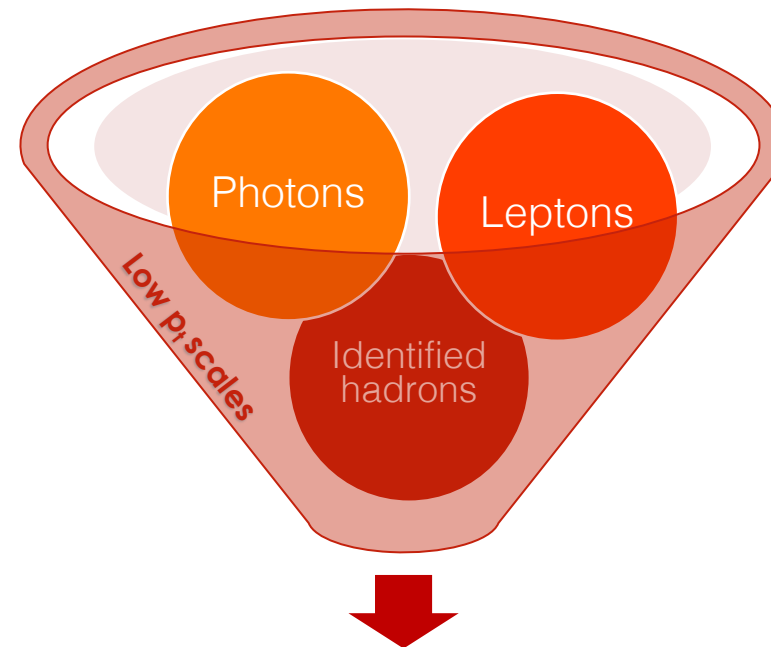
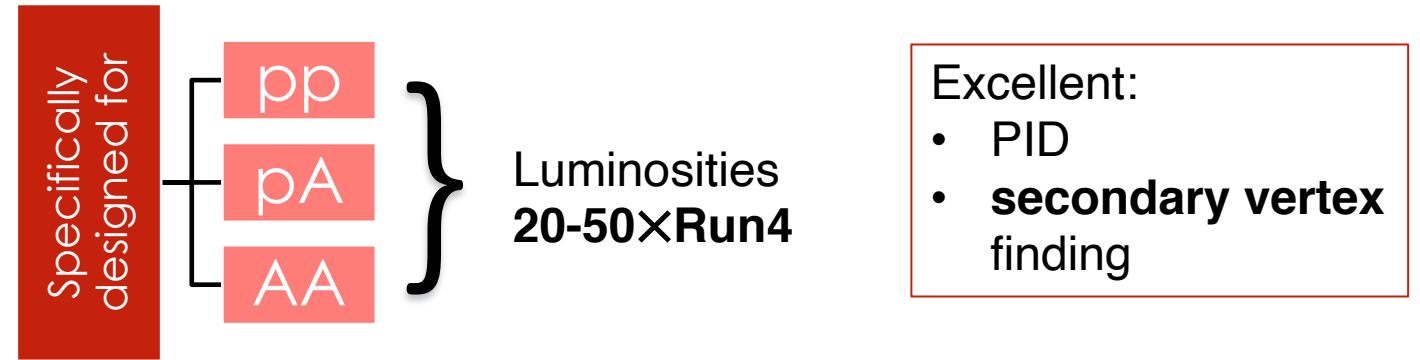
CMOS MAPS

- Low material budget
- High SNR
- Low power
- **Investigation on innovative designs**
→ required time resolution

ALICE 3

- Heavy flavour and quarkonia
- Photons and low-mass dileptons
- Soft and ultra-soft photons
- Other topics

A next-generation LHC heavy-ion experiment



Significant **advances** & rich **physics program**

ALICE 3

Heavy flavour and quarkonia

Photons and low-mass dileptons

Soft and ultra-soft photons

Other topics

Unique tracking and vertexing capabilities

**High-precision
measurements**

Production mechanism of
heavy flavour particles

Crucial new
window on
**hadron
formation**

**Multiply Heavy
Flavoured baryons**

Observation & quantification
enhancement in AA

Test of
hadronization
mechanism in
the QGP

Capability for
**quarkonium
physics**

Prompt & secondary **charmonia**

Properties of **QGP**

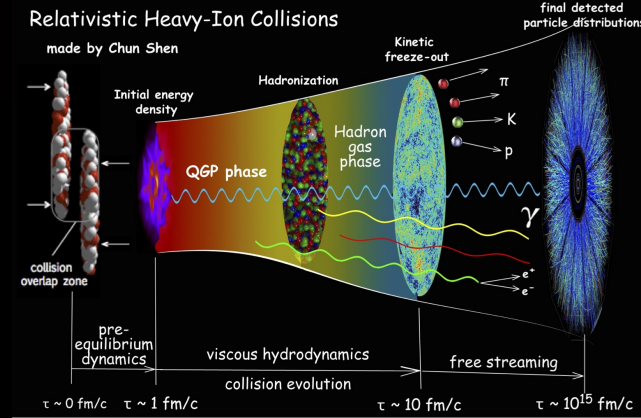
ALICE 3

Heavy flavour and quarkonia

Photons and low-mass dileptons

Soft and ultra-soft photons

Other topics



EM radiation emitted during the
whole lifetime of QGP

p_T very close to the natural scale $\propto 1/R_{\text{system}}$

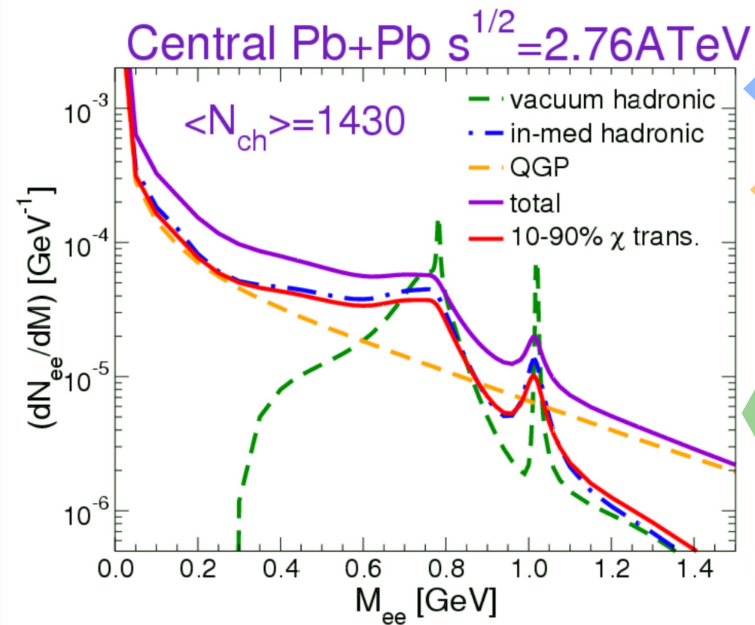
New approach:

Precision measurement of

- photons
- thermal di-leptons



Unique sensitivity to the early
times of the deconfined system



Hadronic production via vector mesons

Thermal production from the plasma

Hadrons decays
without medium
effects

Crucial test for
chiral symmetry
restoration

ALICE 3

Heavy flavour and quarkonia

Photons and low-mass dileptons

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Other topics

Soft and ultra-soft photons
 $p_T \sim 10 \text{ MeV}/c$

Extremely **difficult**

- Huge background from π_0 decays
- e^- bremsstrahlung

Directly connected
to **charged final
state** of QGP

Test the predictions on
radiation in this p_T range

ALICE 3

Heavy flavour and quarkonia

Photons and low-mass dileptons

Soft and ultra-soft photons

Other topics

**PUSH THE BOUNDARIES
IN A NUMBER OF OTHER
AREAS**



Comprehensive **studies** and **simulations** to fully
exploit the **physics potential**